

# **ECE 340 Lectures 37**

# **Semiconductor Electronics**

Spring 2022

10:00-10:50am

Professor Umberto Ravaioli

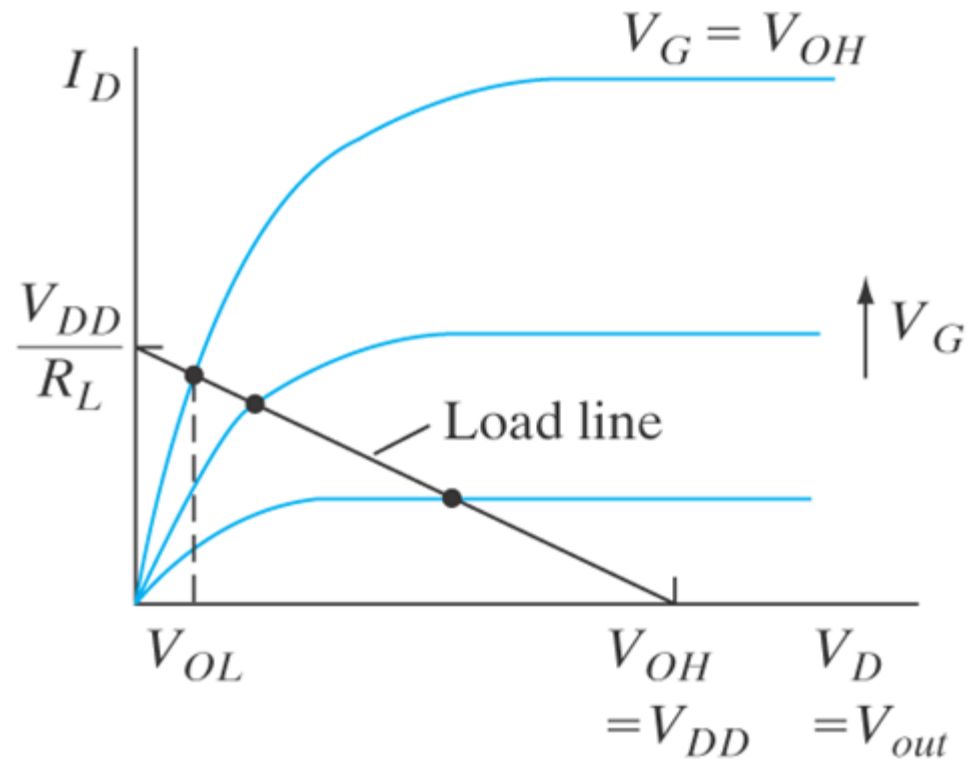
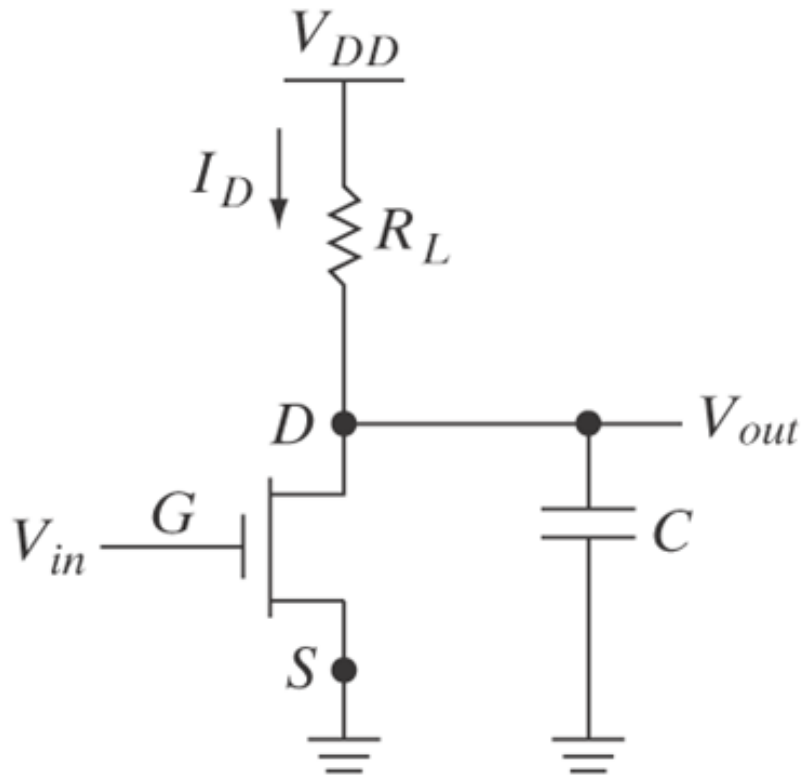
Department of Electrical and Computer Engineering

2062 ECE Building

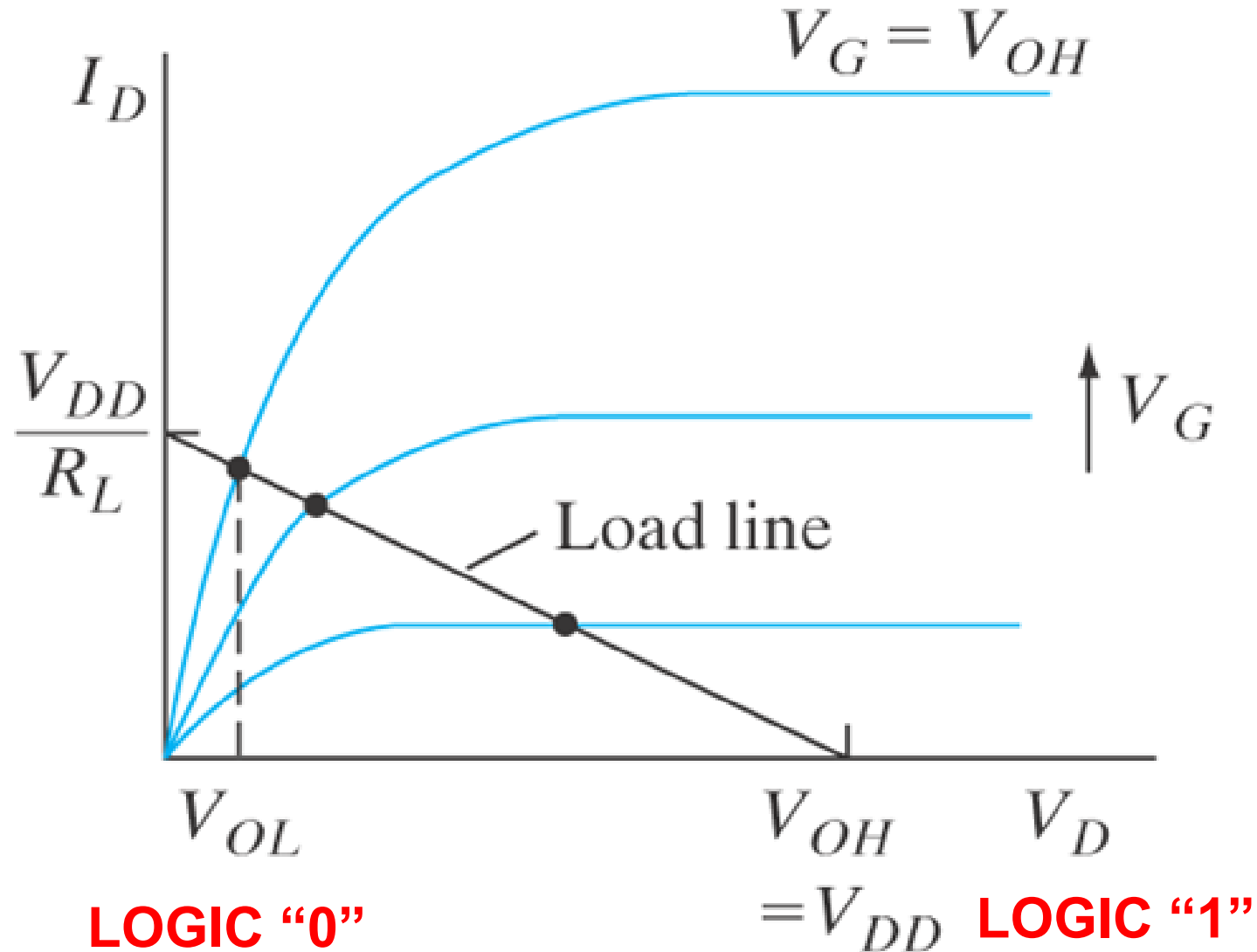
# Today's Discussion

- **Finish MOSFET**
- **Narrow Base Diode**
  - **Motivation: this structure can be considered a precursor to understanding the Bipolar Junction transistor**
- **Introduction to the Bipolar Junction Transistor (BJT)**

# MOS inverter

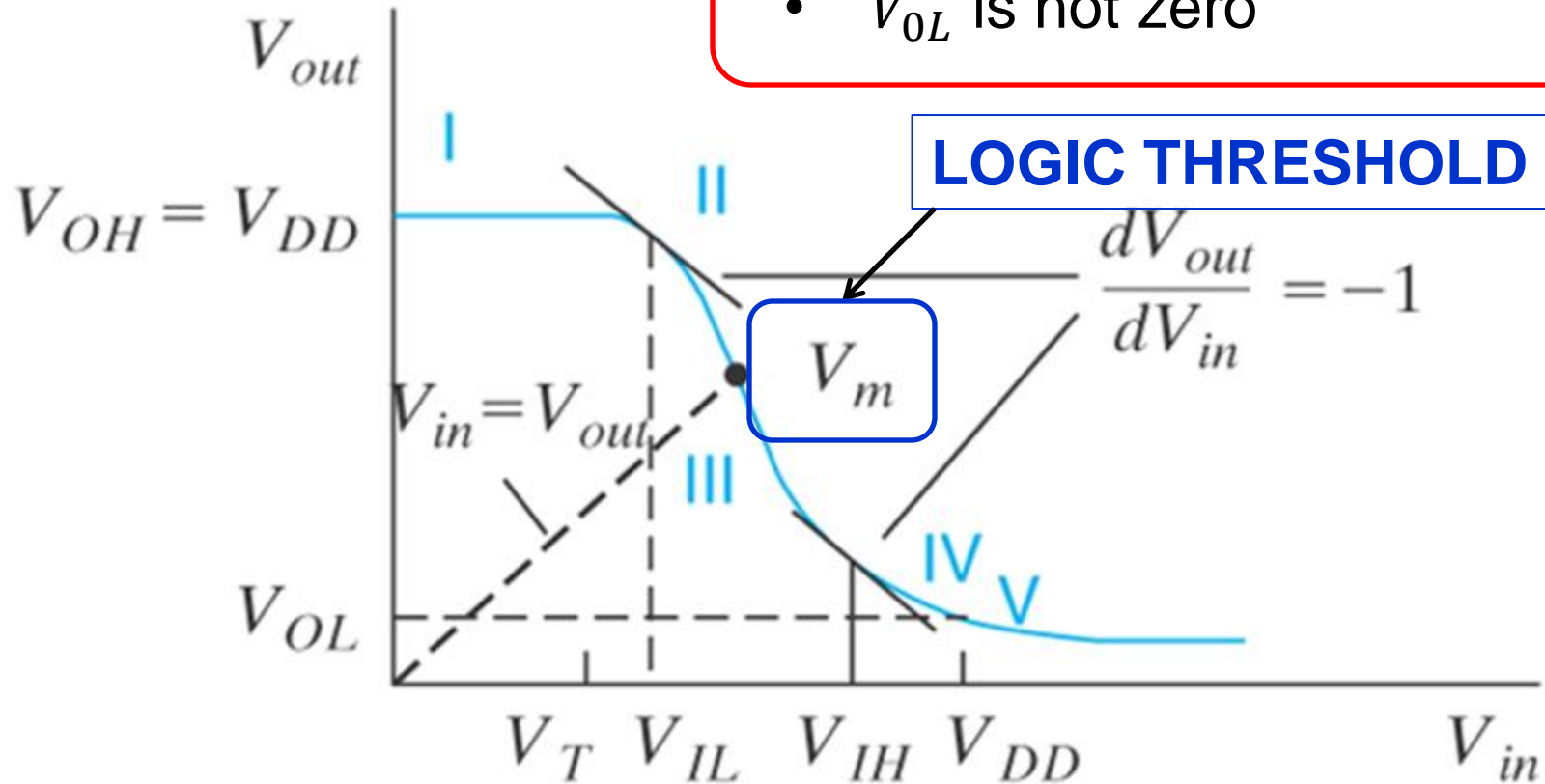


# MOS inverter – Voltage transfer characteristics

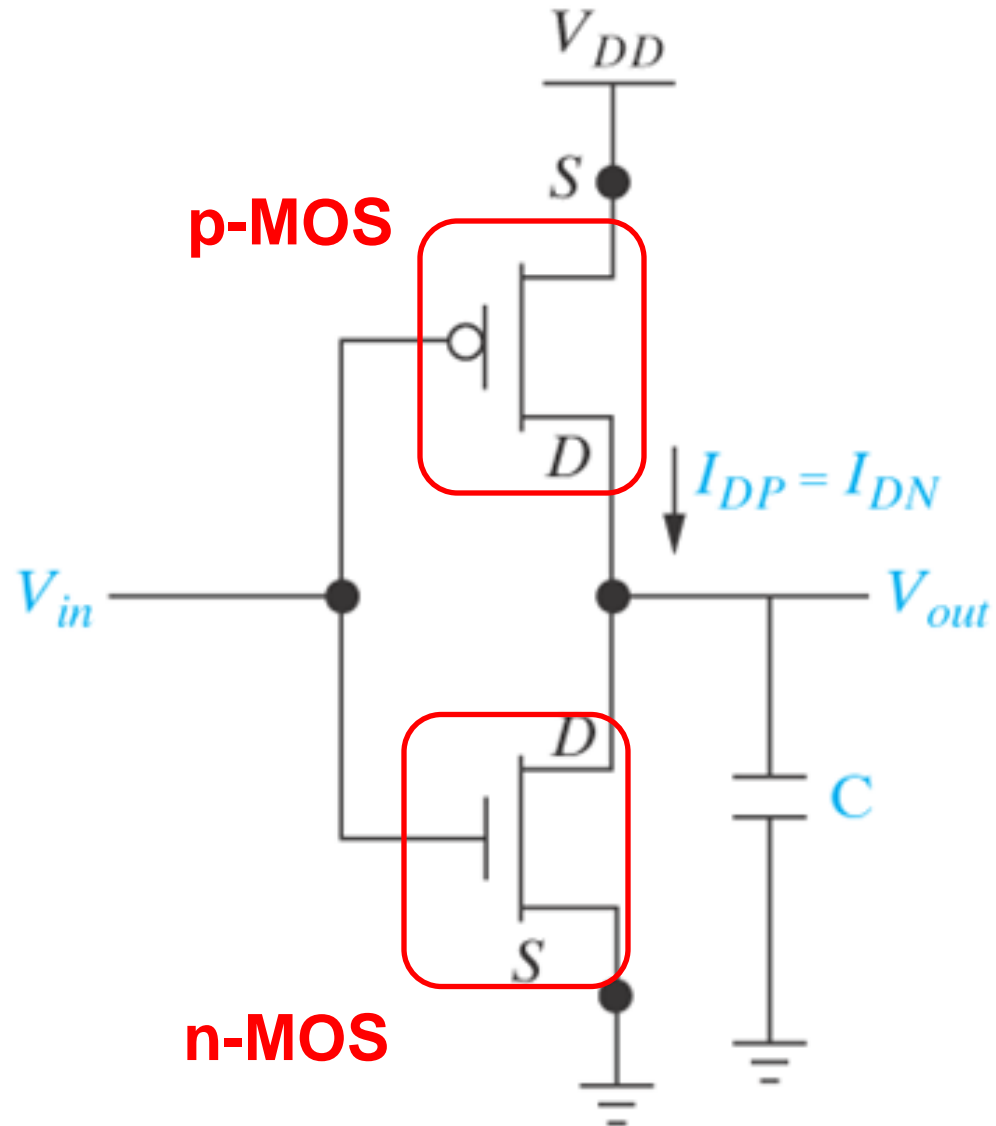


# MOS inverter – Voltage transfer characteristics

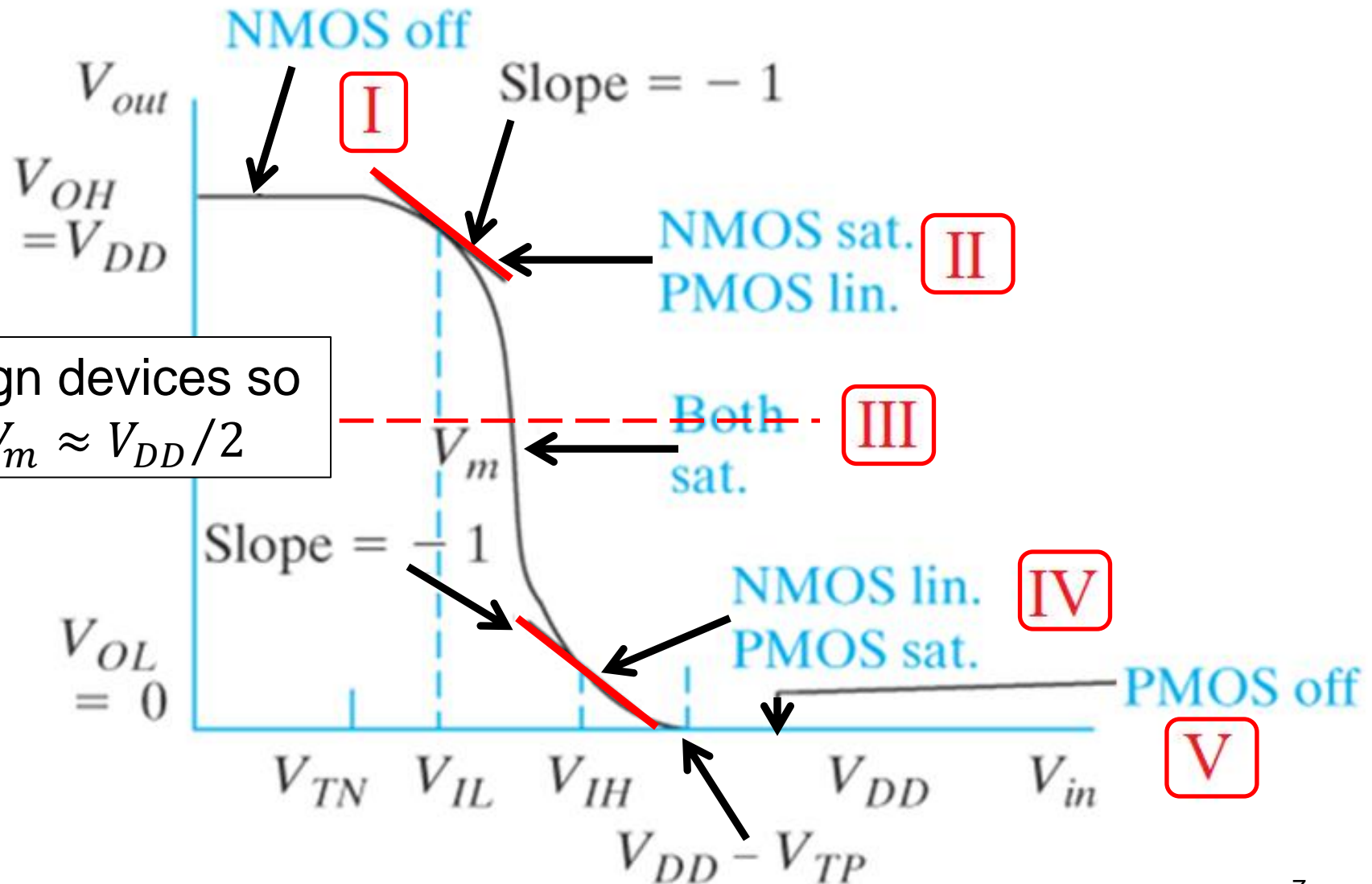
- Power dissipation in resistor
- $V_{OL}$  is not zero



# CMOS inverter



# CMOS inverter – Voltage transfer characteristics



# CMOS inverter – Voltage transfer characteristics

Design devices so that  $V_m \approx V_{DD}/2$       REGION III

Setting  $I_D(\text{NMOSFET}) = I_D(\text{PMOSFET})$

$$\chi = \left( \frac{k_N}{k_P} \right)^{1/2} = \frac{\left[ \overline{\mu}_n C_i \left( \frac{Z}{L} \right)_n \right]^{1/2}}{\left[ \overline{\mu}_p C_i \left( \frac{Z}{L} \right)_p \right]^{1/2}} = 1$$



# CMOS inverter – Voltage transfer characteristics

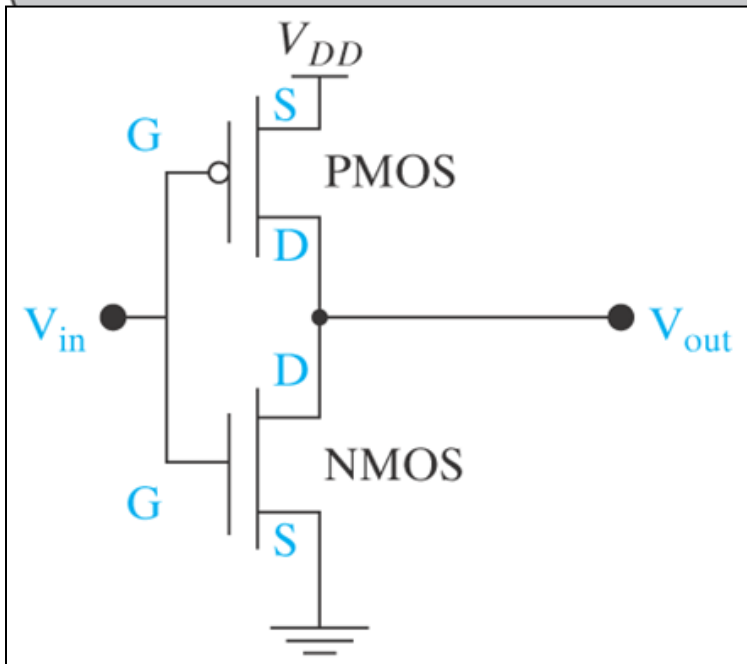
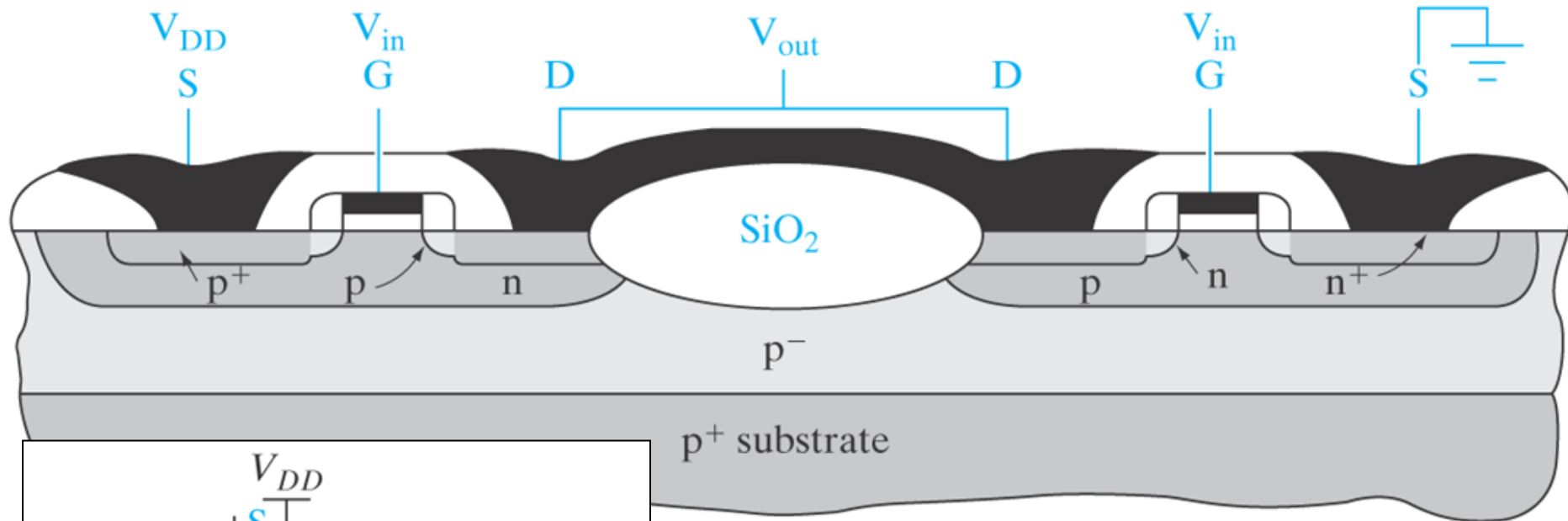
Design devices so that  $V_m \approx V_{DD}/2$       REGION III

$$\chi = \left( \frac{k_N}{k_P} \right)^{1/2} = \frac{\left[ \overline{\mu}_n C_i \left( \frac{Z}{L} \right)_n \right]^{1/2}}{\left[ \overline{\mu}_p C_i \left( \frac{Z}{L} \right)_p \right]^{1/2}} = 1$$

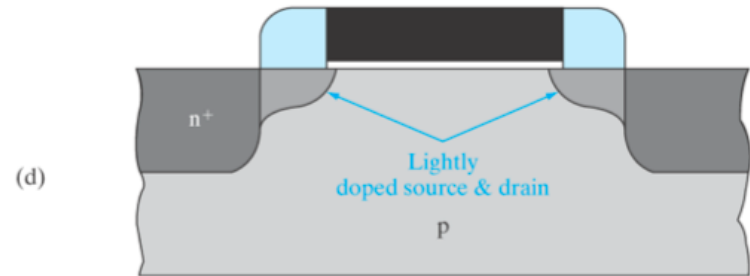
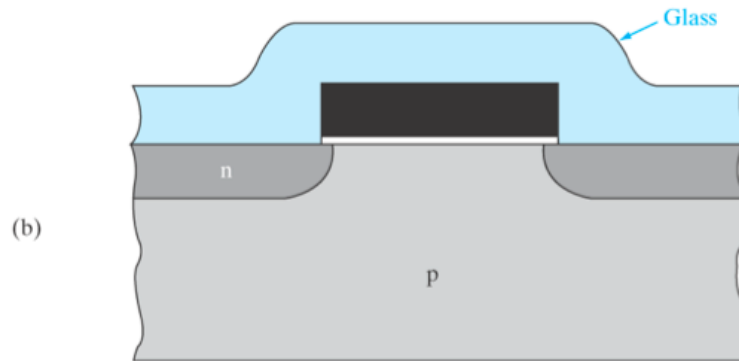
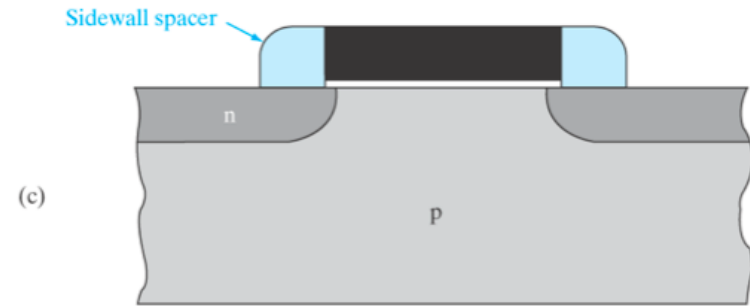
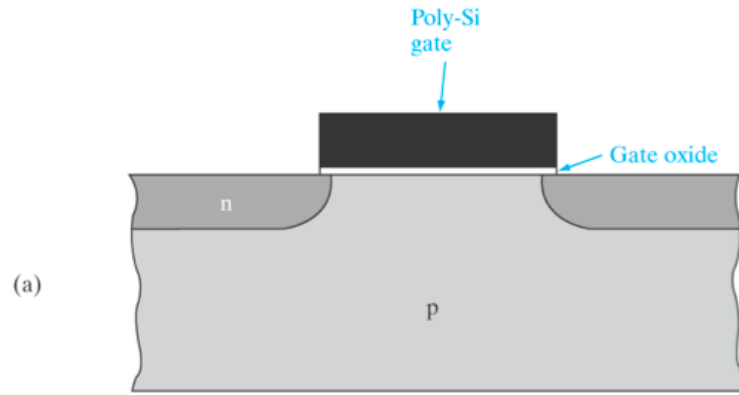
Typically  $\overline{\mu}_n \approx 2\overline{\mu}_p$

$$\chi = 1 \rightarrow (Z/L)_p = 2(Z/L)_n$$

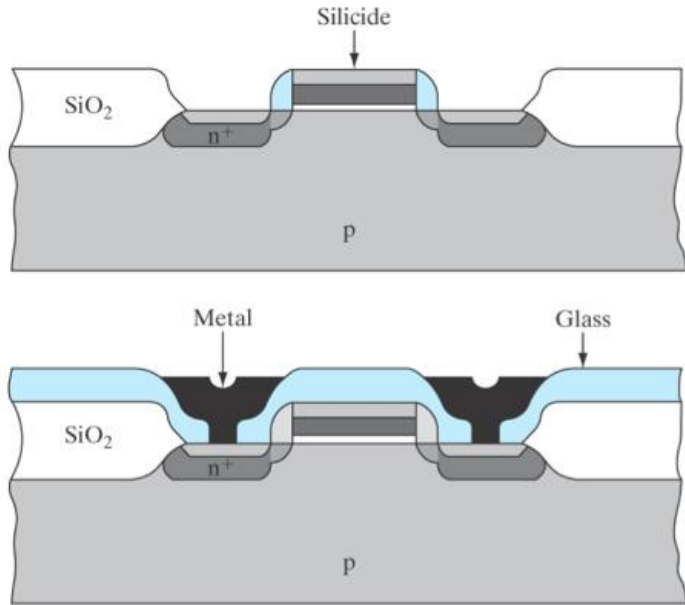
# CMOS integration



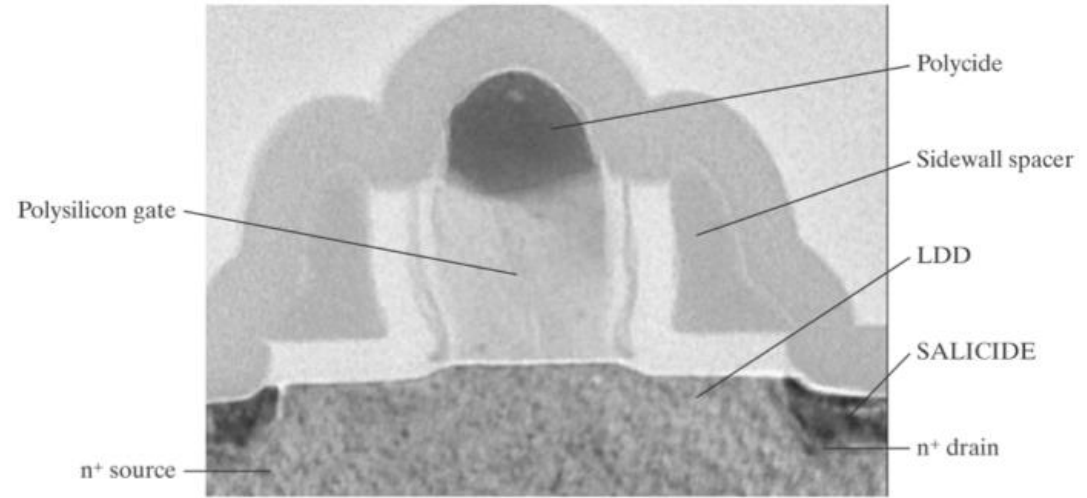
# NMOS Fabrication in p-Well



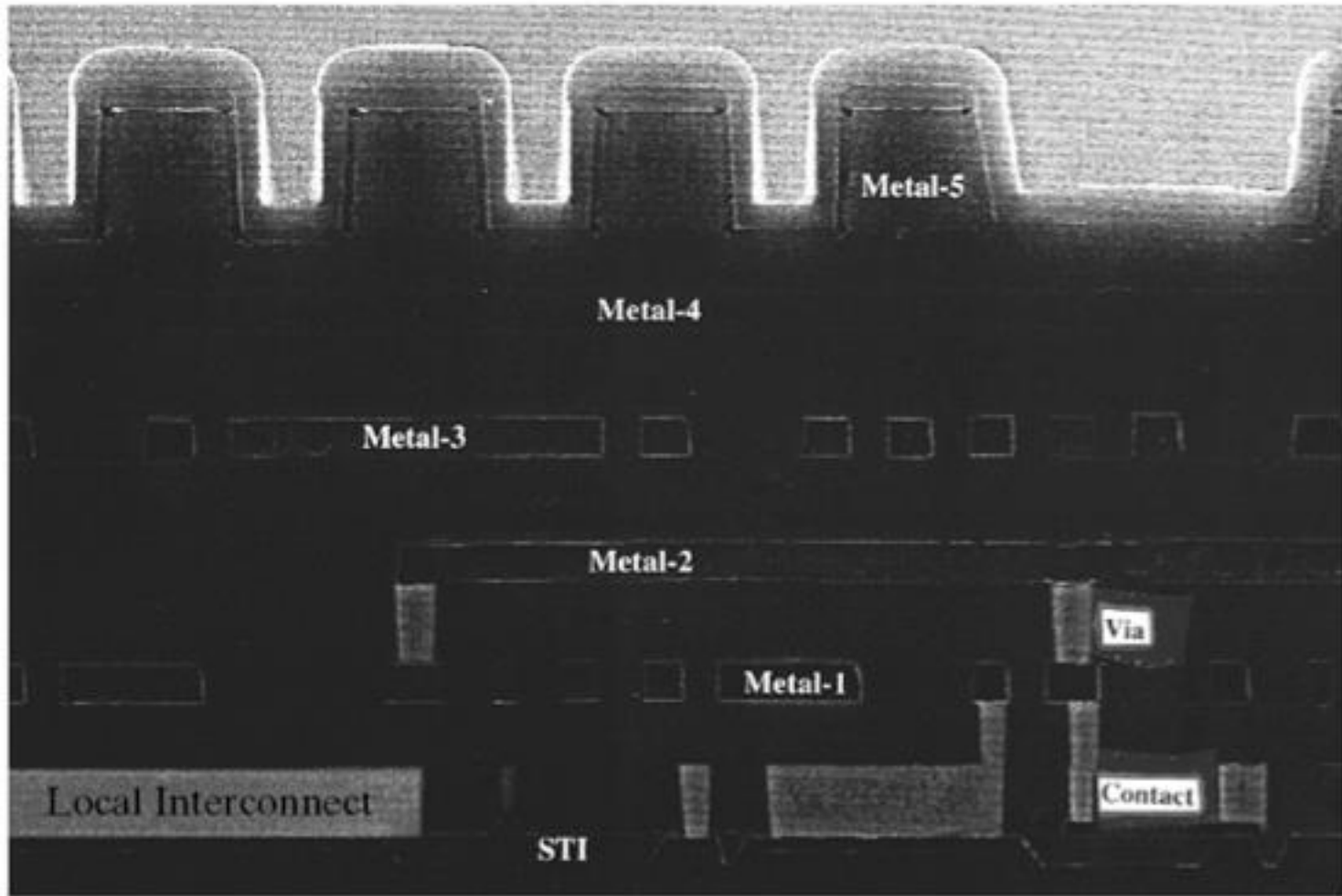
# MOSFET – metal contacts



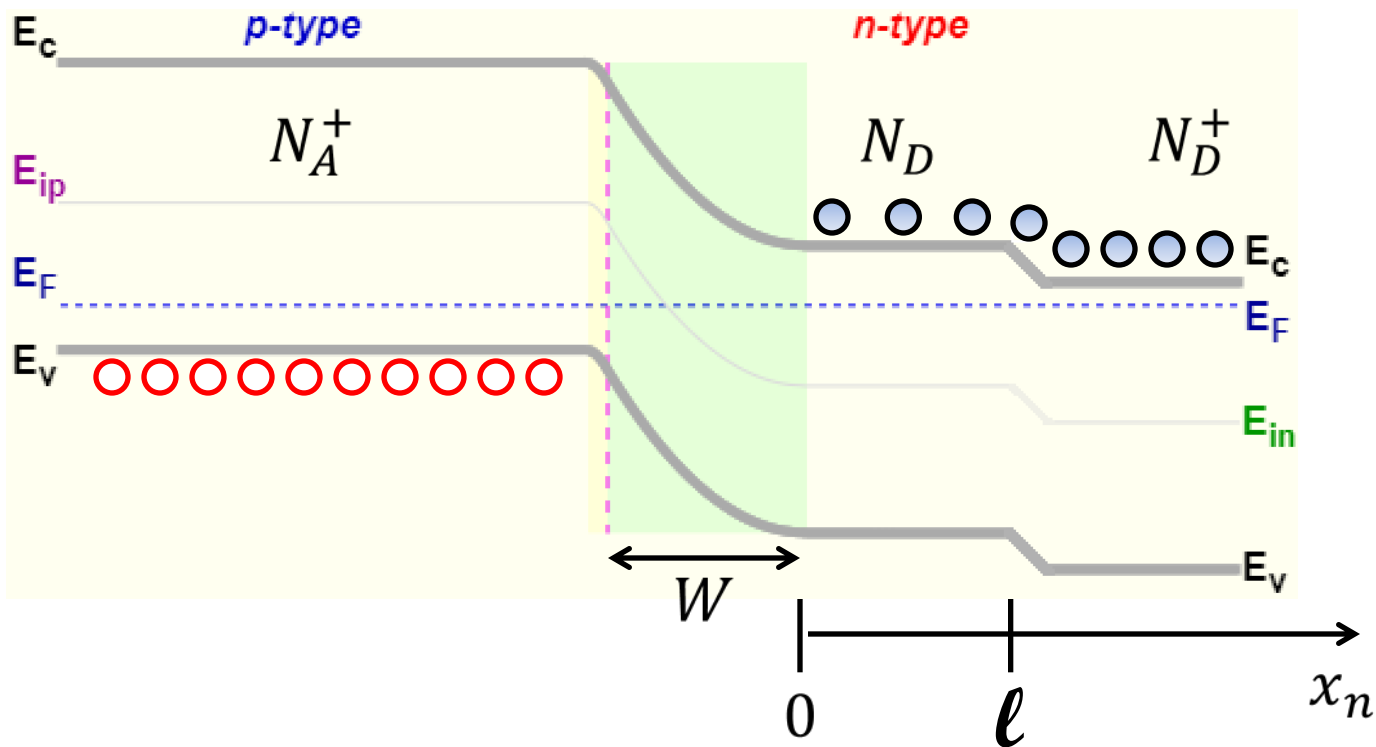
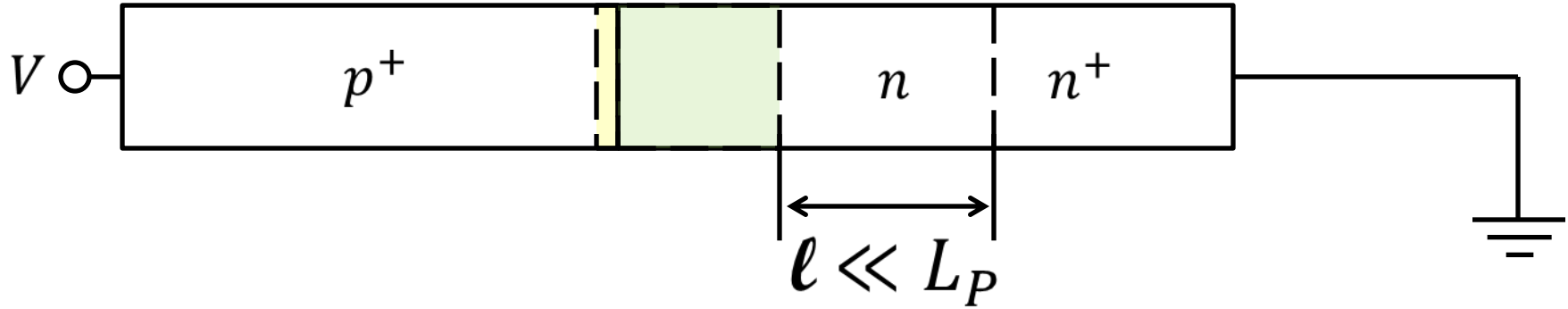
(c)



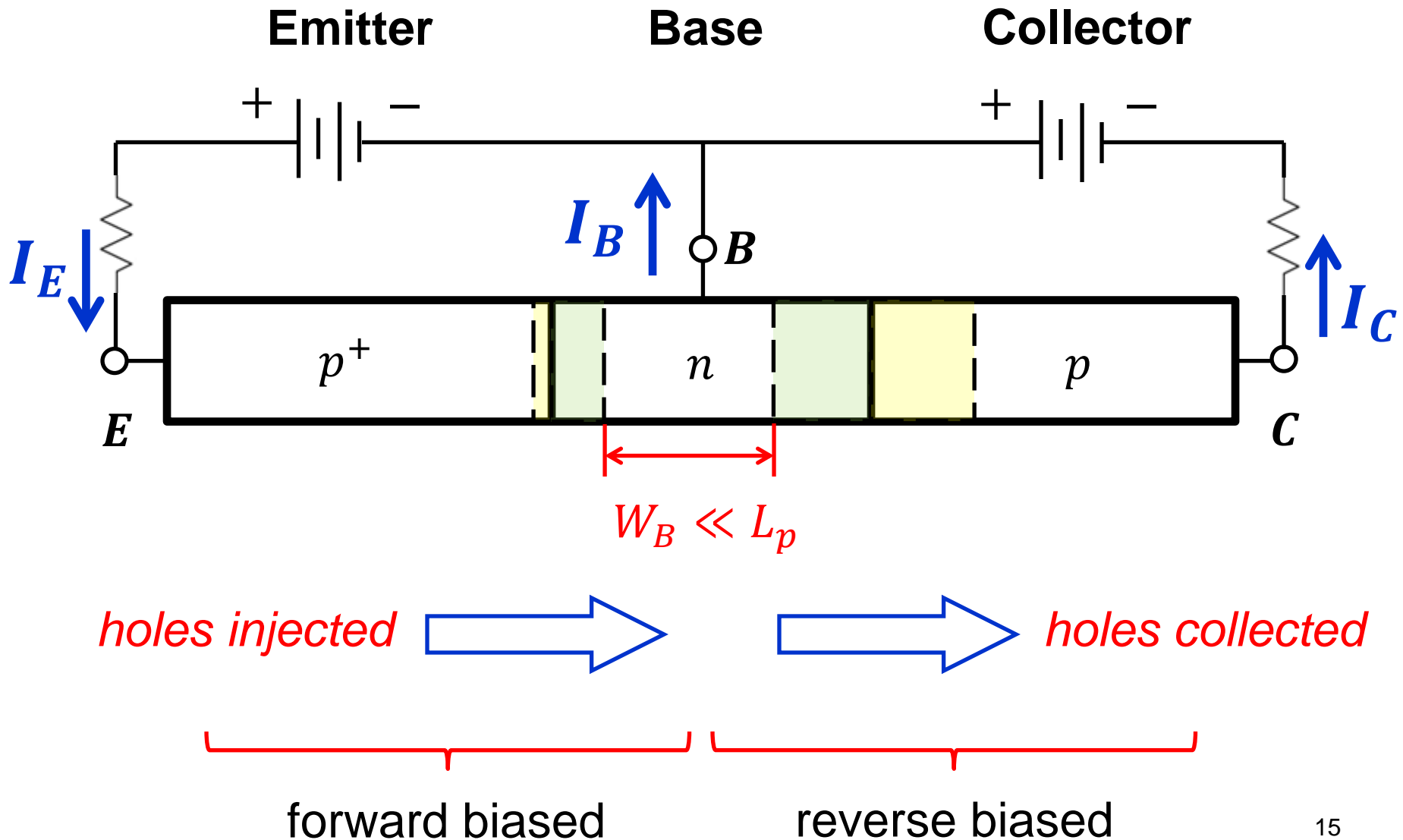
# Multilevel Interconnects



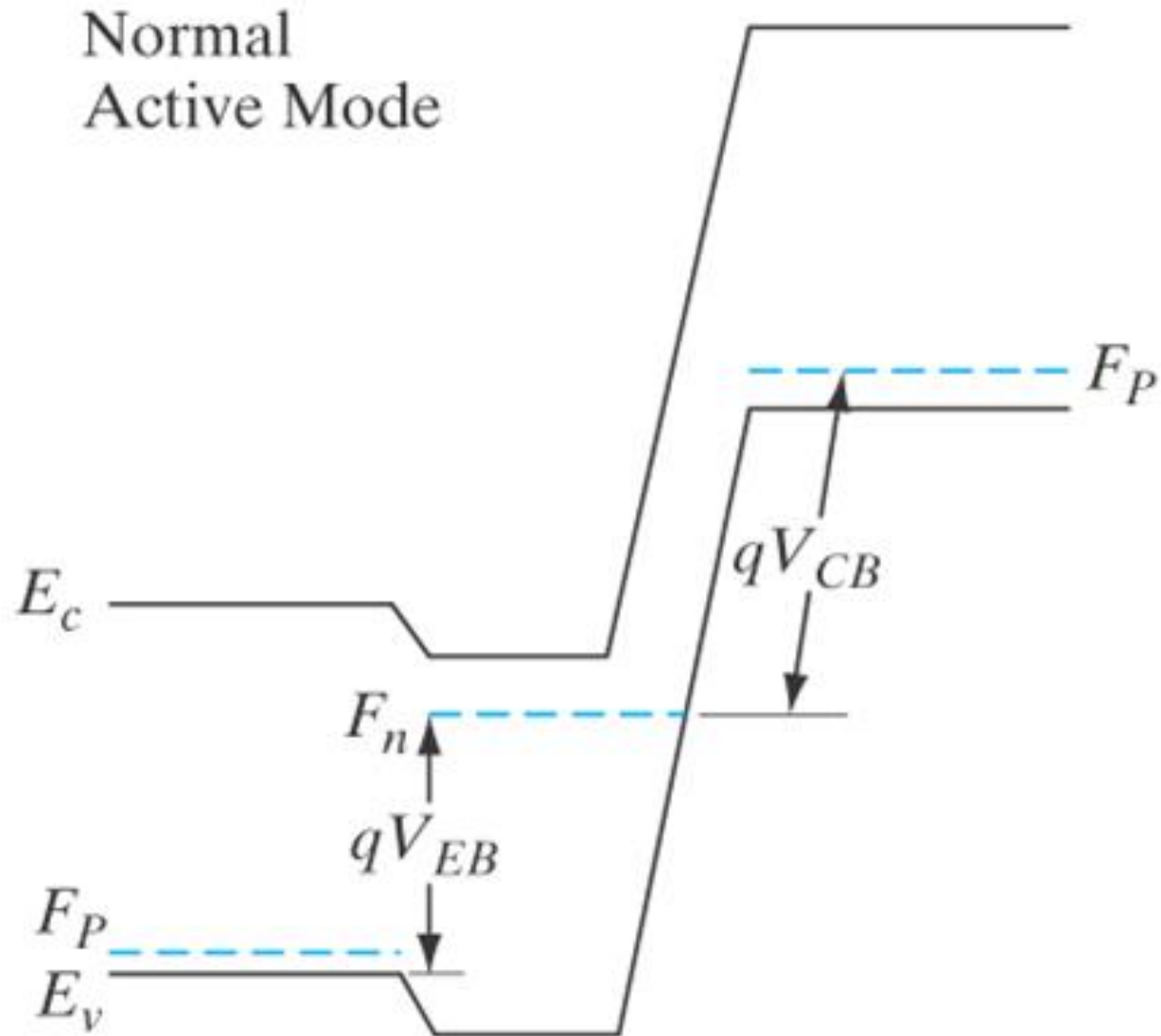
# Narrow Base Diode (N-B-D)



# $p-n-p$ Bipolar Junction Transistor (B-J-T)

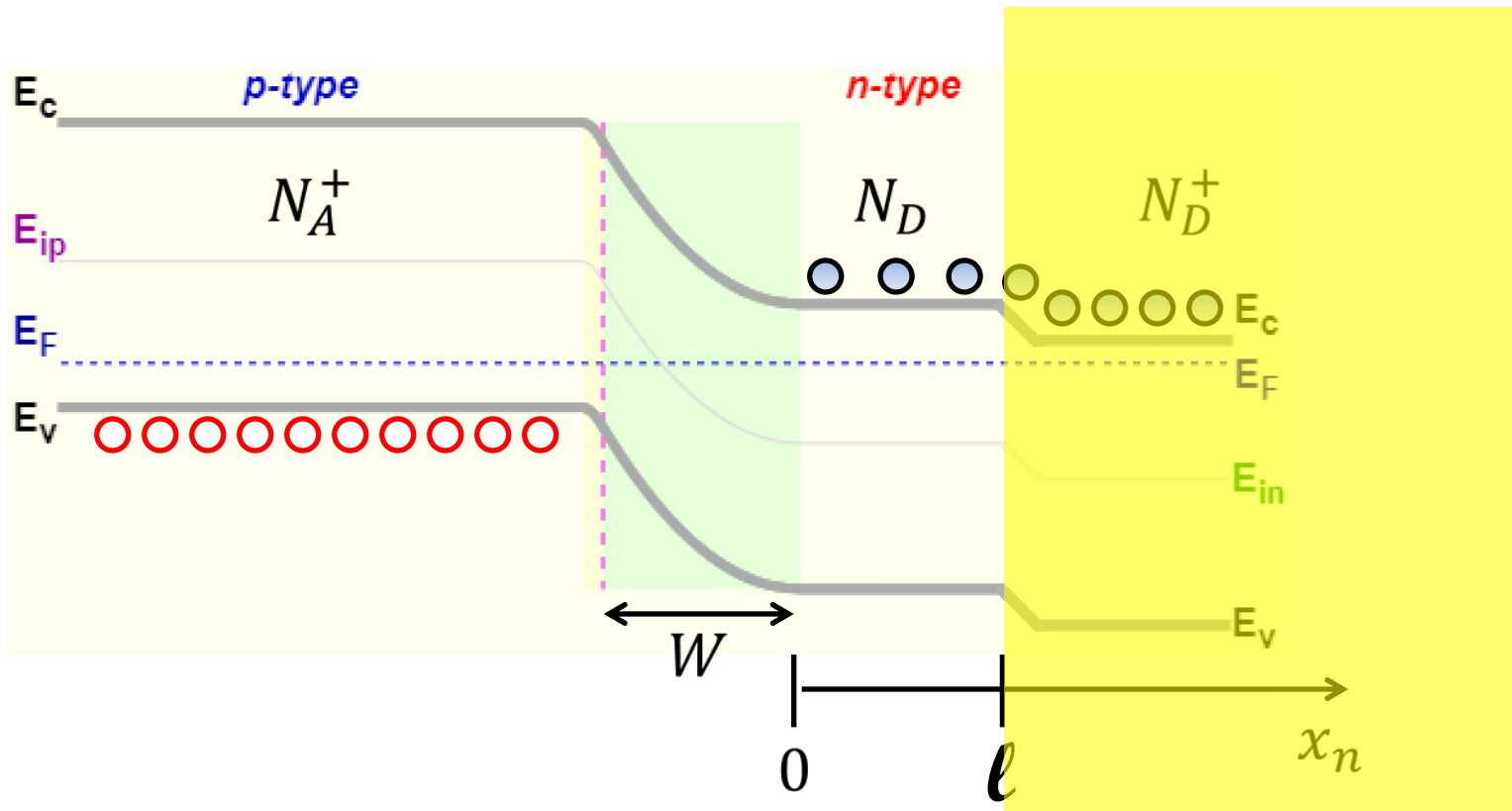


# *p-n-p* B-J-T band diagram



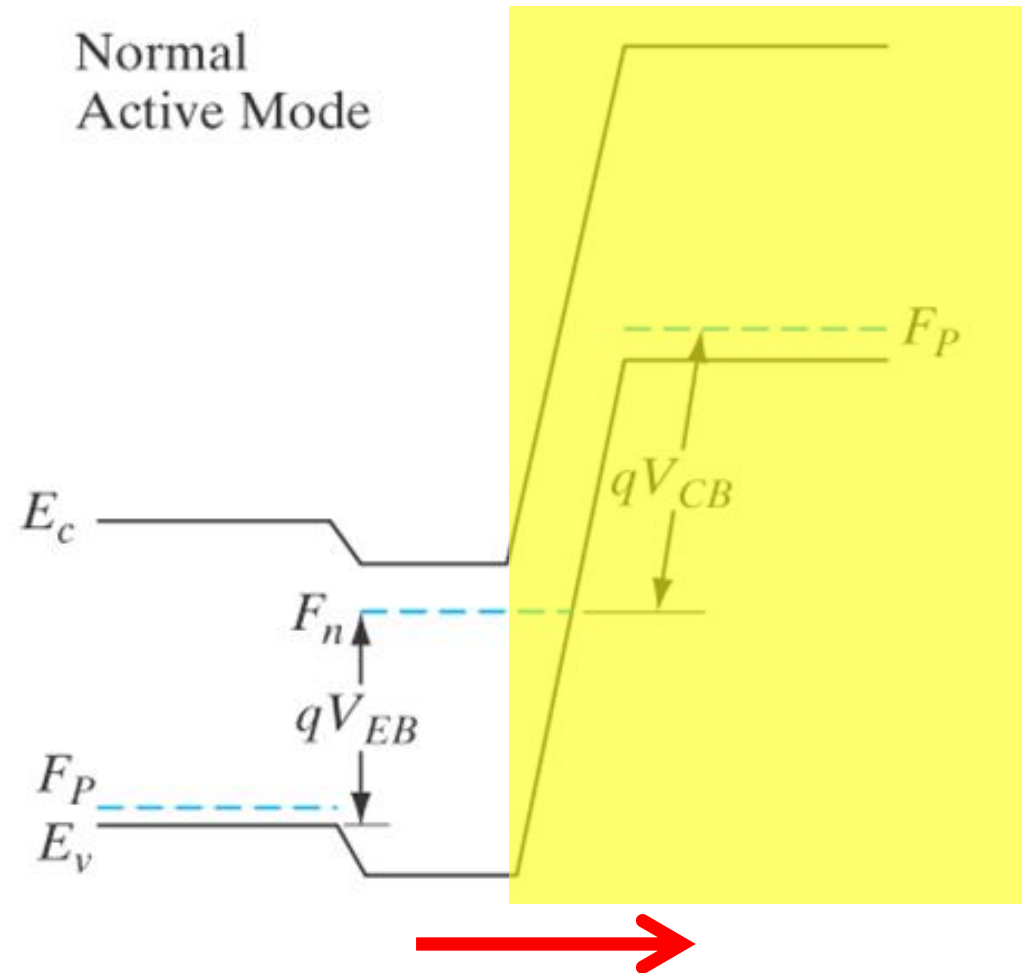


# Similarity between N-B-D and B-J-T



Injected holes are quickly removed by recombination with high  $n^+$  concentration

# Similarity between N-B-D and B-J-T



Holes are quickly removed by high field of reverse biased p-n junction

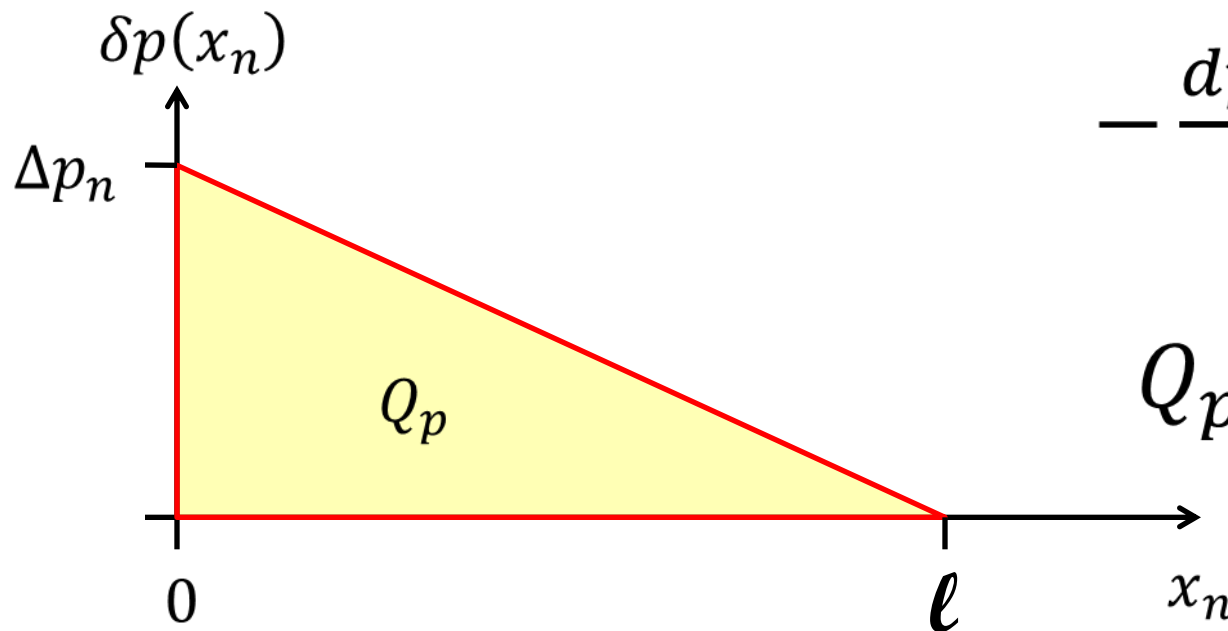
# Narrow Base Diode

- $\ell \ll L_p \sim 1$  to  $10 \mu\text{m}$
- **Boundary conditions for holes is modified by presence of heavily doped  $n^+$ -region**
- **Assume that minority holes recombine immediately when entering the  $n^+$ -region**
- **Hole lifetime is smaller in  $n^+$ -region, approximately according to the ratio  $\frac{N_D^+}{N_D}$**

# Hole boundary conditions

$$\delta p(x_n = 0) = \Delta p_n = p_n \left[ \exp\left(\frac{qV}{k_B T}\right) - 1 \right]$$

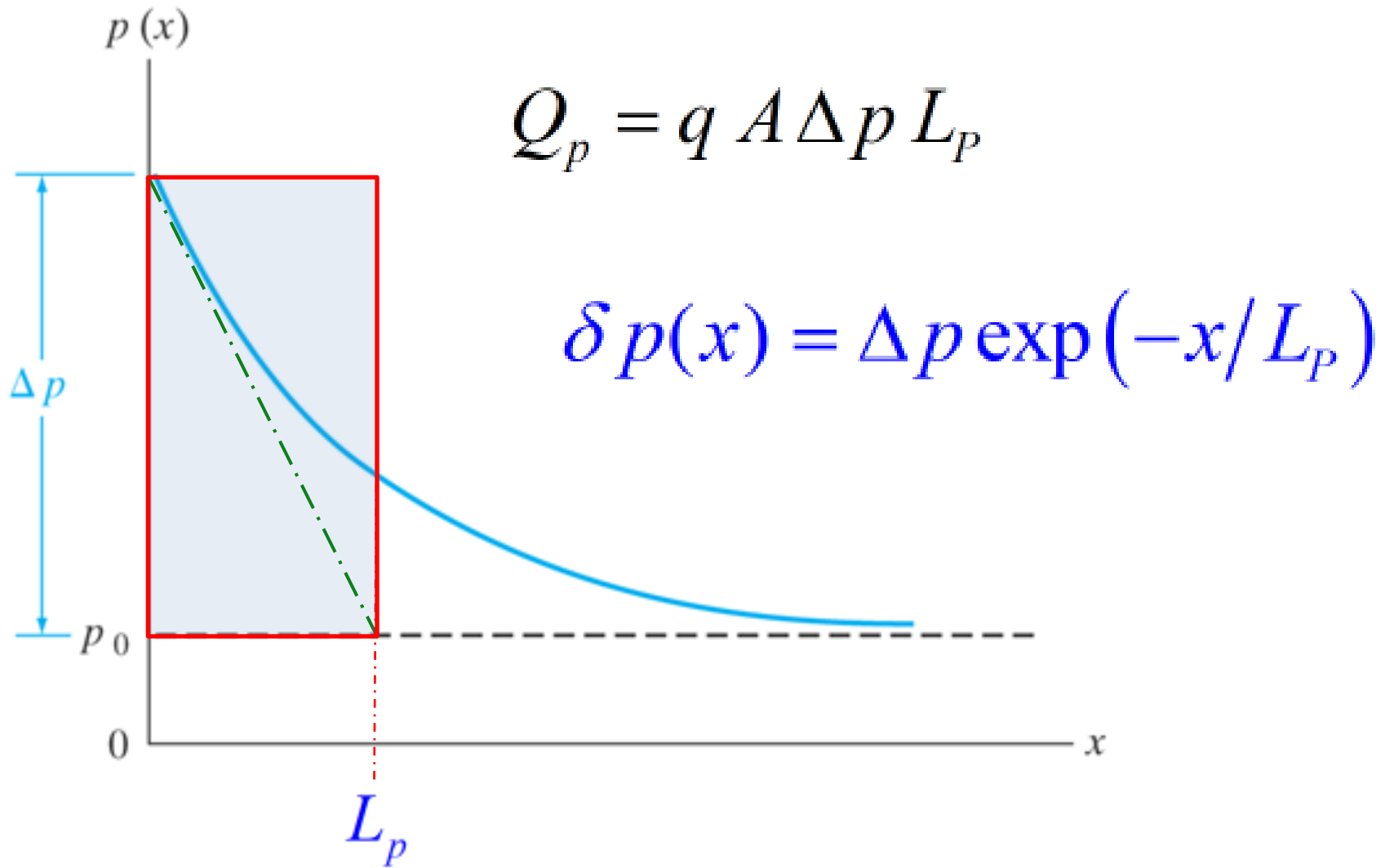
$$\delta p(x_n = \ell) \approx 0$$



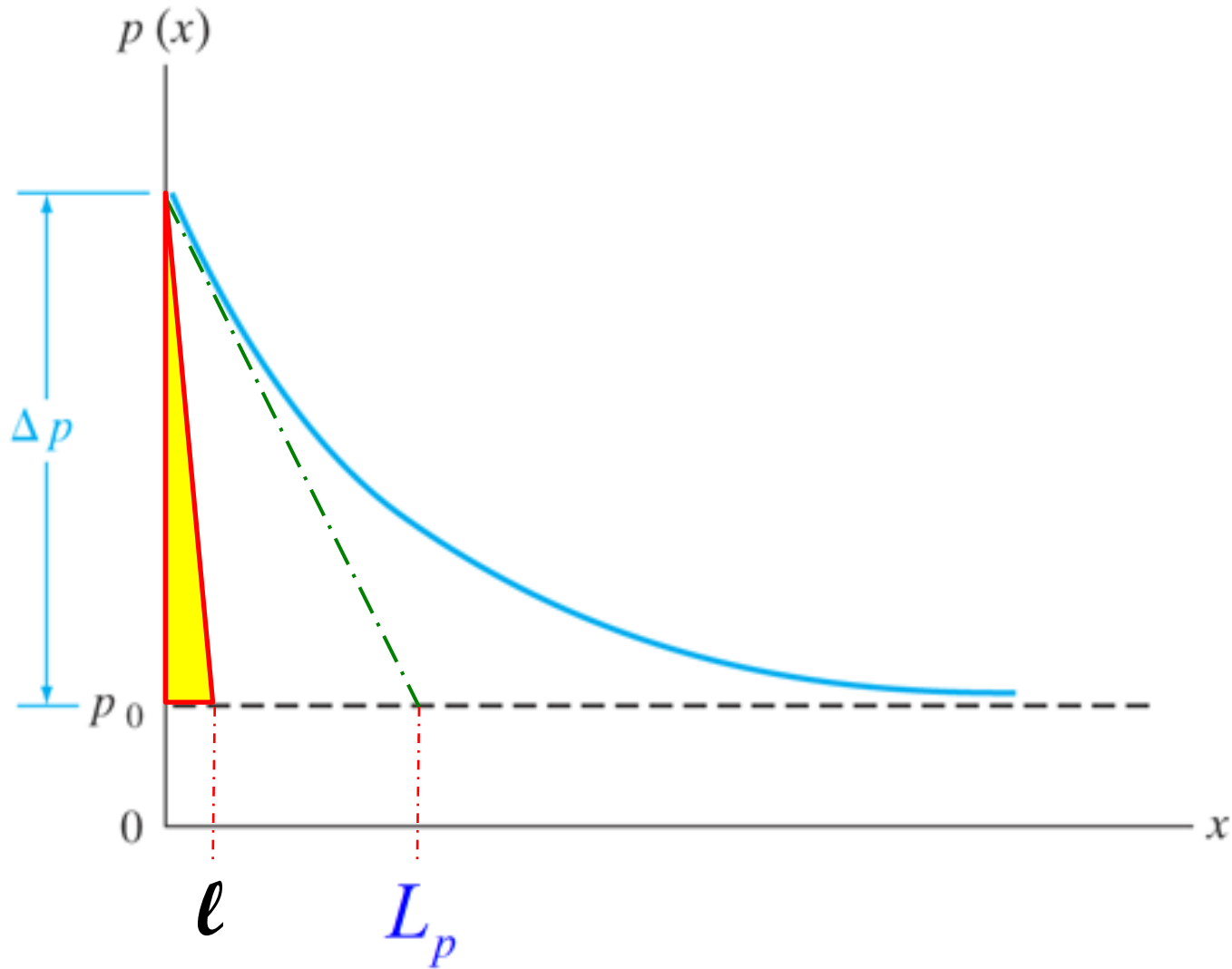
$$-\frac{dp(x_n)}{dx_n} \approx \Delta p_n / \ell$$

$$Q_p \approx \frac{1}{2} qA \ell \Delta p_n$$

# Remember solution for long material



# Compare with narrow base



# Minority hole current – straight line approximation

current density

$$J_p(x_n) \approx J_p(\text{diff}) = -qD_p \frac{dp(x_n)}{dx_n} = qD_p \frac{\Delta p_n}{\ell}$$

total current

$$I_p(x_n) \approx A J_p(\text{diff}) = q A \frac{D_p}{\ell} p_n \left[ \exp\left(\frac{qV}{k_B T}\right) - 1 \right]$$

# Minority hole current

- Diffusion current in this narrow base structure is much larger than in an ordinary  $p^+ - n$  diode for the same voltage since  $\ell \ll L_P$  and  $\ell$  replaces the diffusion length at denominator.
- Essentially, more electrons are dragged in from the  $n^+$ -region to satisfy the  $\Delta p_n \approx 0$  boundary condition.



# Checking straight line approximation

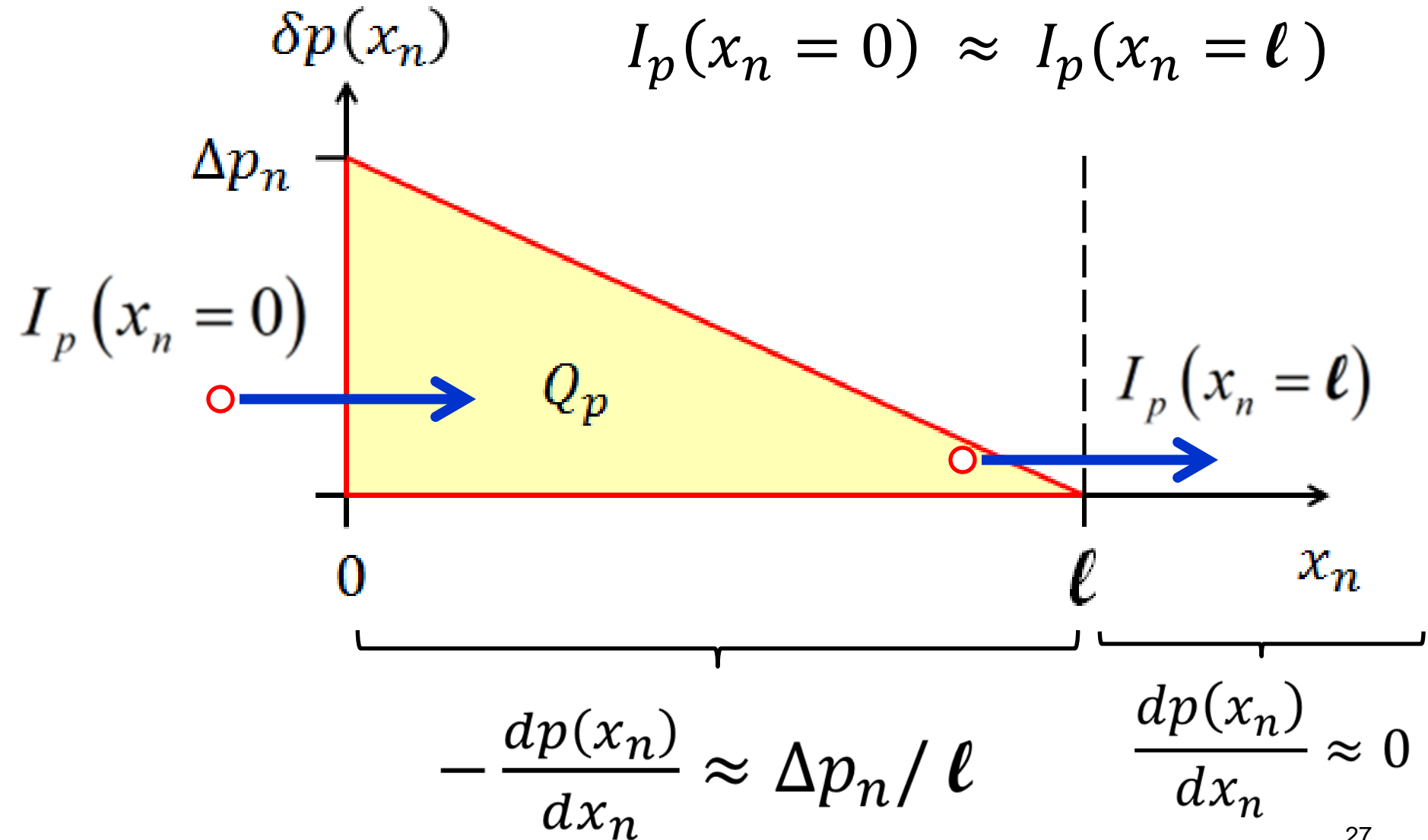
- In **straight-line approximation**, the hole diffusion current is the same throughout the  $n$ -region.
- In reality there is a small decrease which one can estimate examining the recombination rate for stored minority hole charge.

# Checking straight line approximation

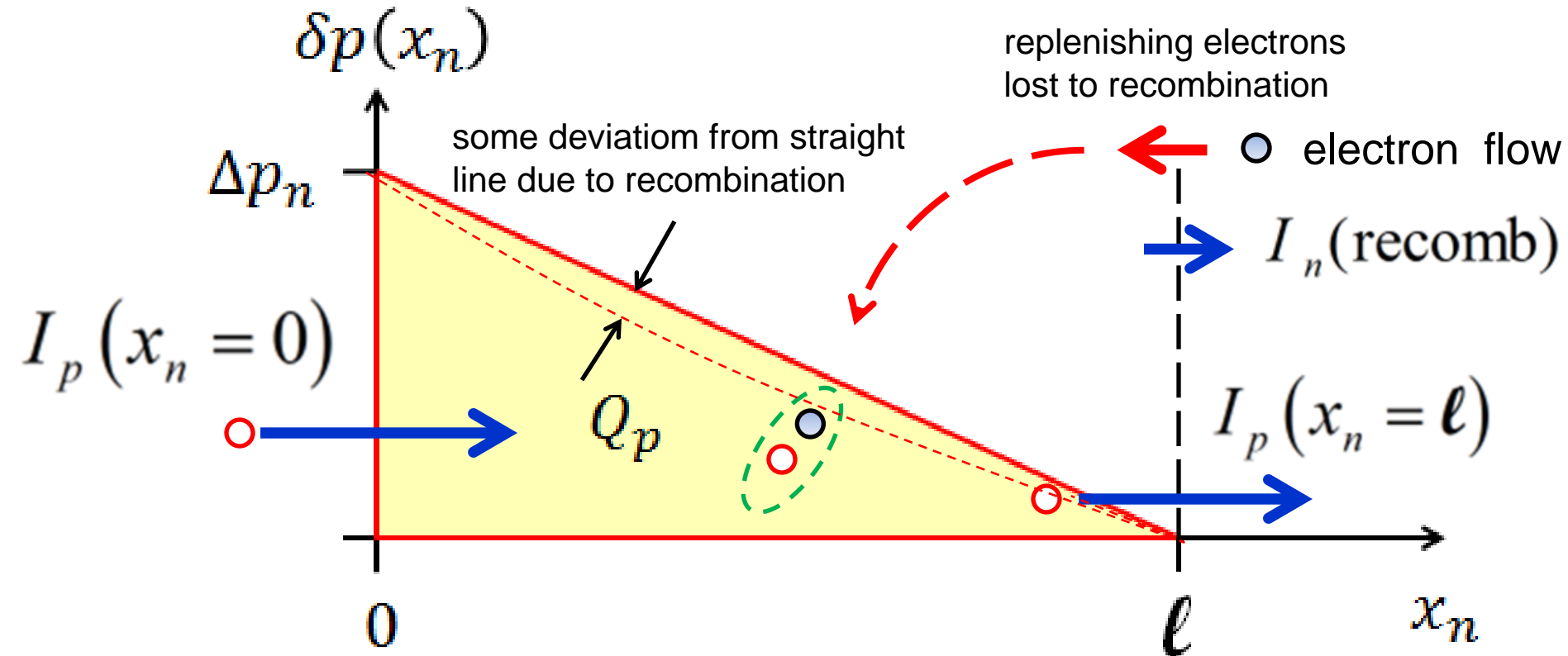
- Each time a hole recombines in the narrow  $n$ -region another electron flows from the  $n^+$  contact region to maintain space-charge neutrality

$$I_n(\text{recomb}) \approx \frac{Q_P}{\tau_p} = \frac{\frac{1}{2} q A \ell \Delta p_n}{\tau_p}$$
$$= \frac{q A \ell}{2 \tau_p} p_n \left[ \exp\left(\frac{qV}{k_B T}\right) - 1 \right]$$

# Hole boundary conditions



# Beyond straight line approximation



$$I_p(x_n = 0) = I_p(x_n = \ell) + I_n(\text{recomb})$$

# Majority electron current

- The majority electron current flowing into the  $n$ -region at  $x_n = \ell$  compensates for the decrease in hole diffusion due to recombination in the base region

$$I_n(\text{recomb}) = I_p(x_n = 0) - I_p(x_n = \ell)$$

$$\approx I_p(x_n = 0) \left[ \frac{\ell^2}{2L_p^2} \right]$$

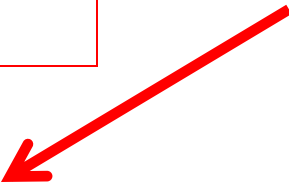
**result of rigorous  
analysis**

# Majority electron current

$$I_n(\text{recomb}) \approx I_p(x_n = 0) \left[ \frac{\ell^2}{2L_p^2} \right]$$

**straight-line  
approximation  
holds well**

very small since  
 $\ell \ll L_p$


$$-\frac{dp(x_n)}{dx_n} \approx \Delta p_n / \ell = \text{constant}$$

- holds fairly well throughout  $n$ -region

# Conclusions

Although an exact solution of the diffusion equation is possible, the straight line approximation offers intuitive understanding of the diode behavior.

For length of the base less than  $\sim 0.5 L_p$  the straight line approximation yields very good results. The approximations for derivative of hole concentration and stored charge can be used safely

$$-\frac{dp(x_n)}{dx_n} \approx \Delta p_n / \ell$$

$$Q_p \approx \frac{1}{2} qA \ell \Delta p_n$$

# Conclusions

There is also a component of electron current injected into the  $p^+$  region which is negligible but which can be calculated with the standard diode equation

$$I_n (\text{inj}) = -q A \frac{D_n}{L_n} n_p \left[ \exp\left(\frac{qV}{k_B T}\right) - 1 \right]$$

We will see that in the bipolar transistor with a  $p^+ - n - p$  structure, a third terminal can inject instead a current into the base to control the much larger hole current, leading to amplification.



# Handout

- Download from the website the handout prepared by the ECE 340 staff, with material on the narrow base diode and on the bipolar junction transistor.

# Exact Solution (1D diffusion equation) – 1

Assume constant cross sectional area. An exact solution of the diffusion equation is obtained from linear combination of exponentials

$$\delta p(x_n) = \Delta p_n \frac{\exp\left(\frac{\ell - x_n}{L_p}\right) - \exp\left(\frac{x_n - \ell}{L_p}\right)}{\exp\left(\frac{\ell}{L_p}\right) - \exp\left(-\frac{\ell}{L_p}\right)}$$

with boundary conditions

$$\delta p(x_n = 0) = \Delta p_n = p_n \left[ \exp\left(\frac{qV}{k_B T}\right) - 1 \right]$$

$$\delta p(x_n = \ell) \approx 0$$

# Exact Solution (1D diffusion equation) – 2

At any point of the  $n$ -region

$$\begin{aligned} I_p(x_n) &= -qAD_p \frac{d}{dx} \delta p(x_n) \\ &= qA \frac{D_p}{L_p} \Delta p_n \frac{\exp\left(\frac{\ell - x_n}{L_p}\right) - \exp\left(\frac{x_n - \ell}{L_p}\right)}{\exp\left(\frac{\ell}{L_p}\right) - \exp\left(-\frac{\ell}{L_p}\right)} \end{aligned}$$

# Exact Solution (1D diffusion equation) – 3

At  $x_n = 0$

$$\begin{aligned} I_p(x_n = 0) &= qA \frac{D_p}{L_p} \Delta p_n \operatorname{ctnh}\left(\frac{\ell}{L_p}\right) \\ &= qA \frac{D_p}{\ell} \Delta p_n \left[1 + \frac{\ell^2}{3L_p^2}\right] \quad \ell \ll L_p \end{aligned}$$

using the expansion  $\operatorname{ctnh}(y) \sim y^{-1} [1 + y^2/3 + \dots]$

For  $\ell \gg L_p$  we have  $\operatorname{ctnh}(y) \rightarrow 1$

we recover the standard diode equation (long base)

# Exact Solution (1D diffusion equation) – 4

At  $x_n = \ell$

$$I_p(x_n = \ell) = qA \frac{D_p}{L_p} \Delta p_n \operatorname{csch}\left(\frac{\ell}{L_p}\right)$$
$$= qA \frac{D_p}{\ell} \Delta p_n \left[1 - \frac{\ell^2}{6L_p^2}\right] \quad \ell \ll L_p$$

using the expansion  $\operatorname{csch}(y) \sim y^{-1} [1 - y^2/6 + \dots]$

slightly less than  $I_p(x_n = 0)$

# Exact Solution (1D diffusion equation) – 5

majority electron current flowing into the base to offset recombination of holes

$$I_n(\text{recomb}) = I_p(x_n = 0) - I_p(x_n = \ell)$$

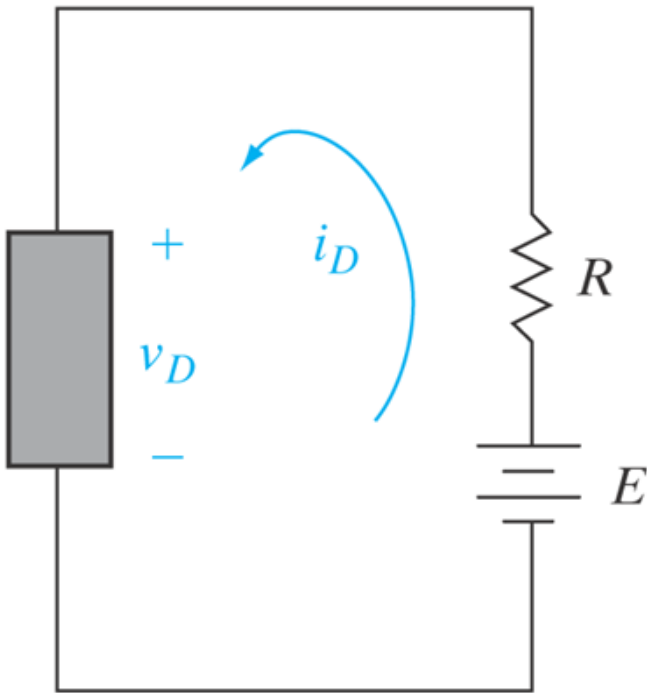
$$= qA \frac{D_p}{L_p} \Delta p_n \tanh\left(\frac{\ell}{2L_p}\right)$$

$$= qA \frac{D_p}{\ell} \Delta p_n \left[ \frac{\ell^2}{2L_p^2} \right] \quad \ell \ll L_p$$

- **Transistor Operation**
- **Introduction to the Bipolar Junction Transistor (BJT)**

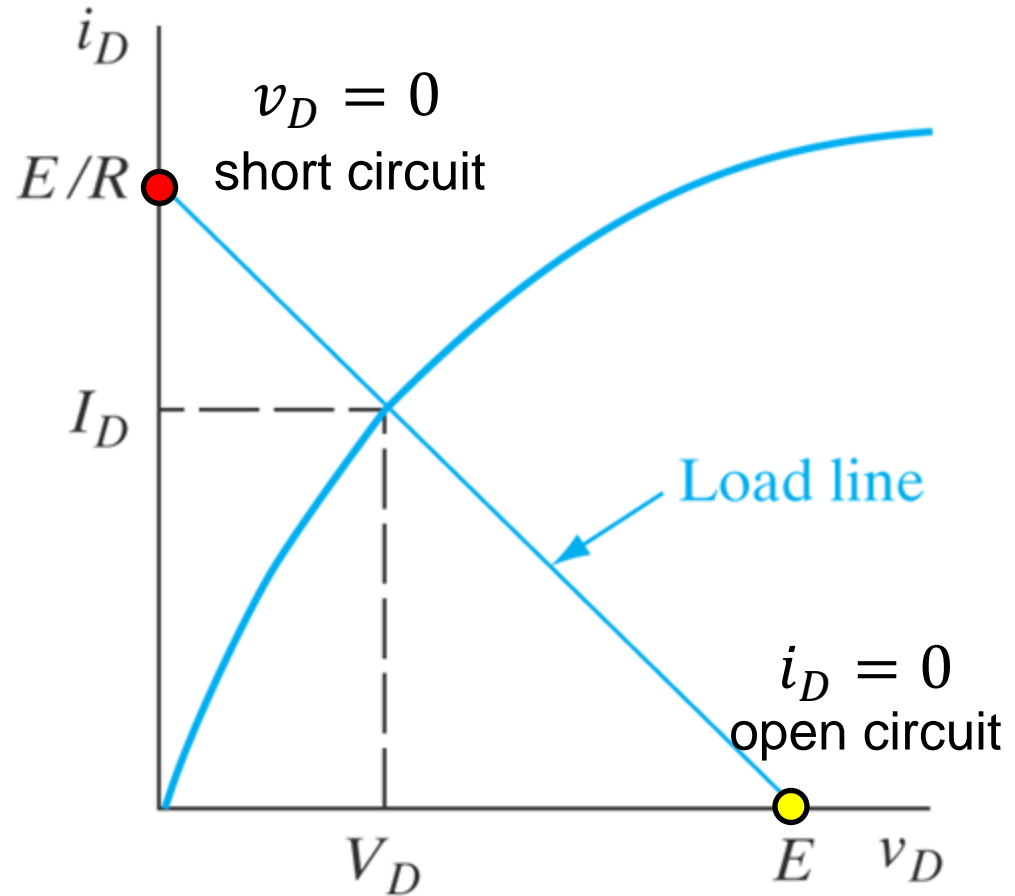
# Graphical solution of circuit

- The load line in a two-terminal device



$$E = i_D R + v_D$$

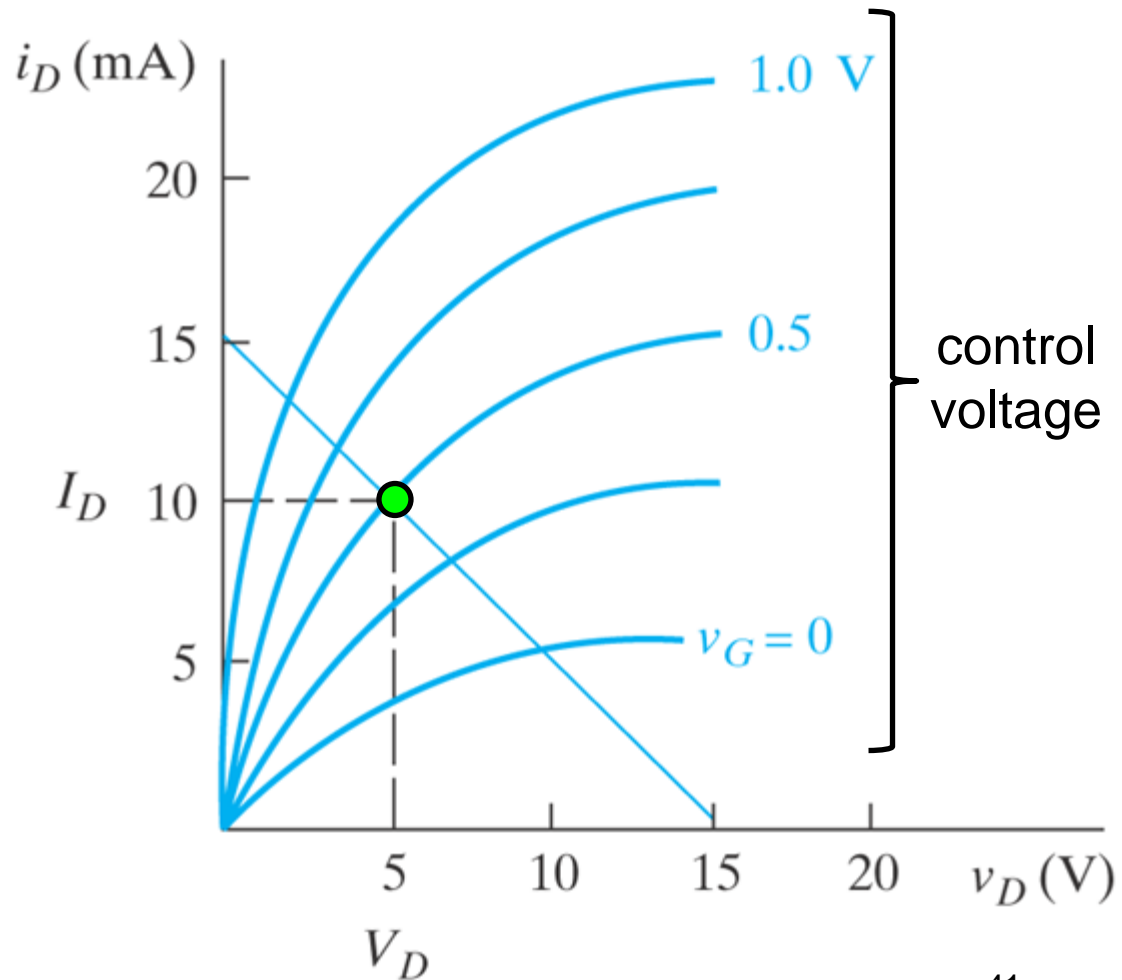
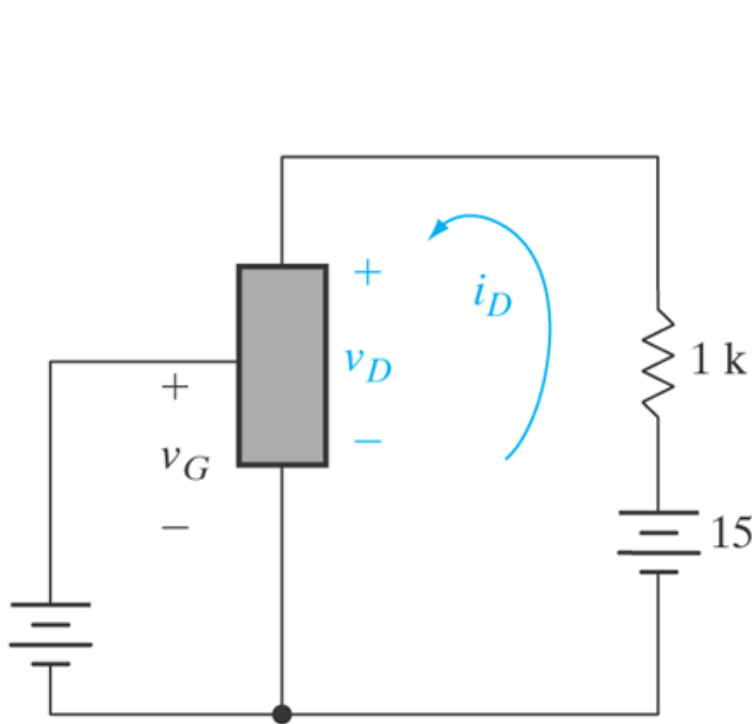
load line equation





# Graphical solution of circuit

- The load line in a three-terminal device



$V_G = 0.5$  V

$V_D = 5$  V  
 $I_D = 10$  mA

# Amplification

a.c. component added to the control input  
generates large variation of the output

From the graph

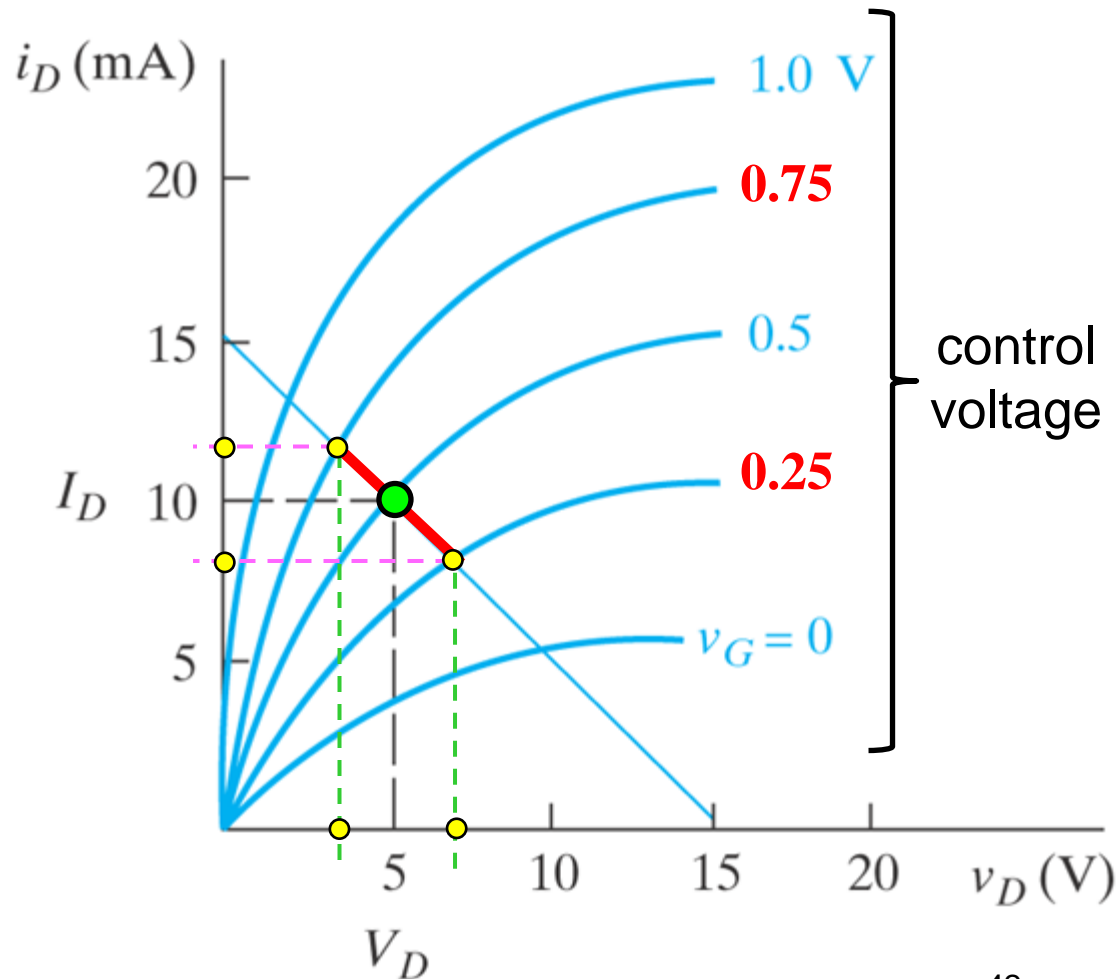
$$\Delta V_G = 0.75 - 0.25 = 0.5 \text{ V}$$

$$\Delta V_D \approx 7.0 - 3.0 = 4 \text{ V}$$

$$\Delta I_D \approx 12.0 - 8.0 = 4 \text{ mA}$$

Gain

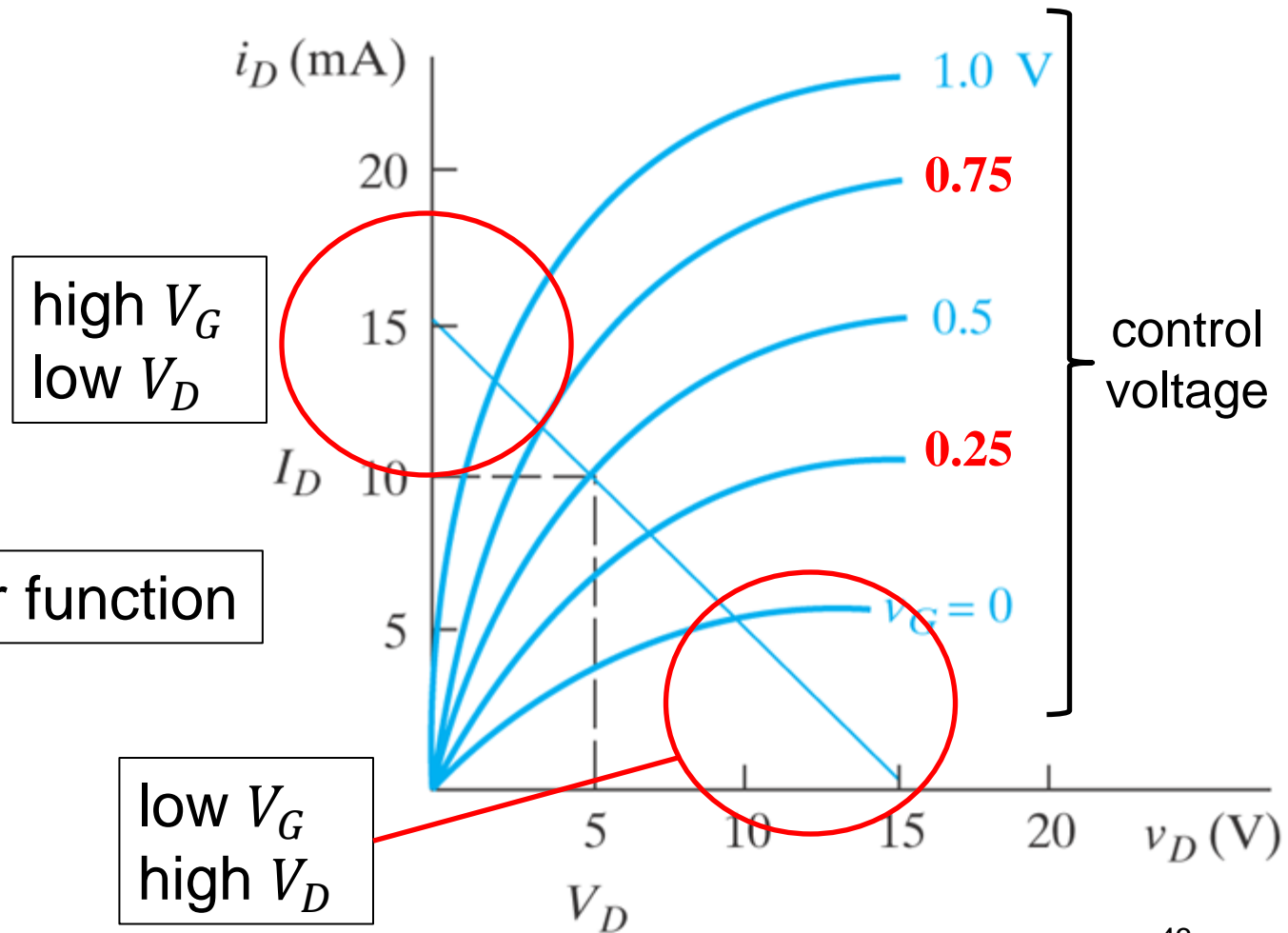
$$|G_V| \approx 8$$



# Switching

$V_G$  = input

$V_D$  = output

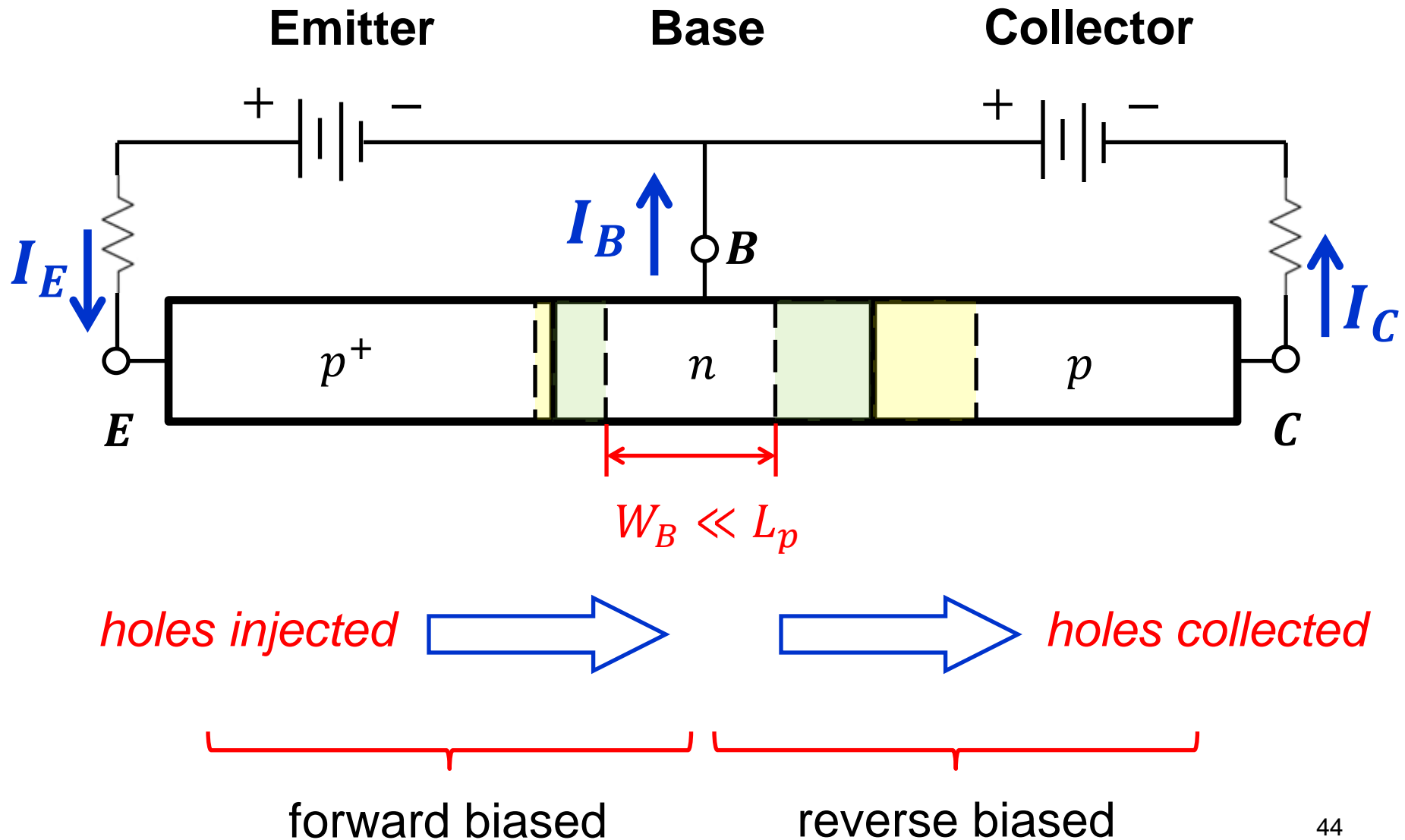


high  $V_G$   
low  $V_D$

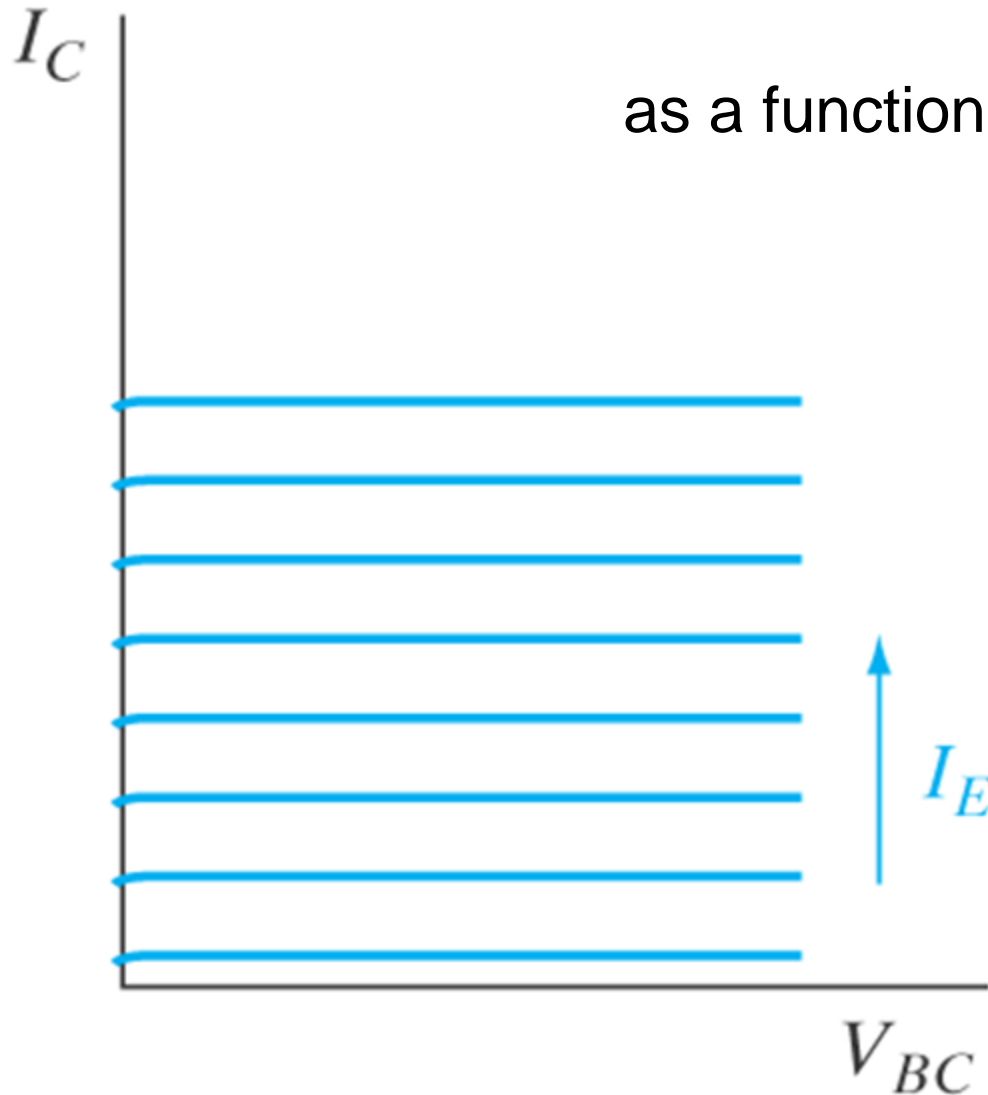
basic inverter function

low  $V_G$   
high  $V_D$

# Bipolar Junction Transistor ( $p-n-p$ )



# I-V curves of the reverse-biased junction

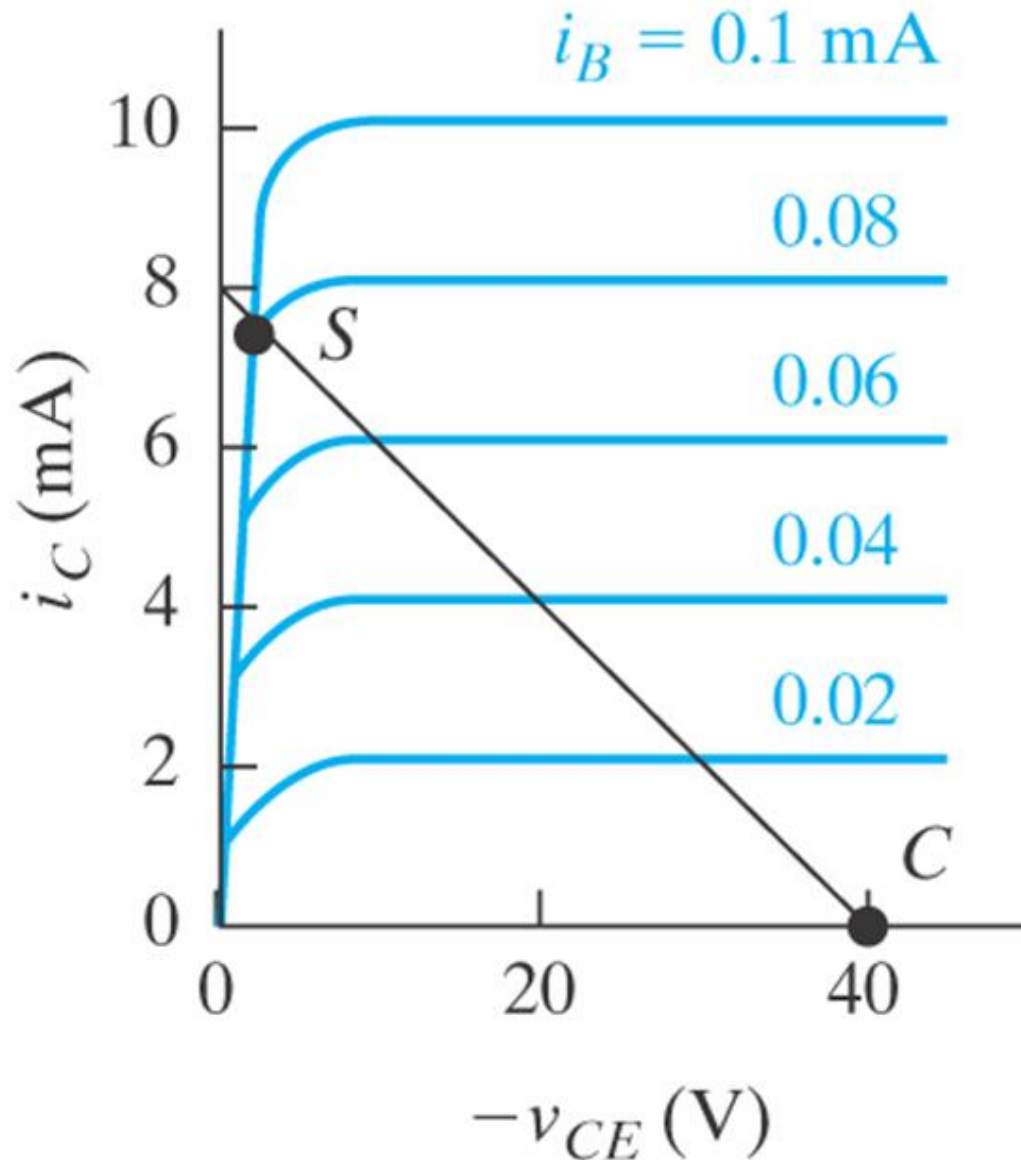


as a function of emitter current

resembles behavior  
of the photodiode

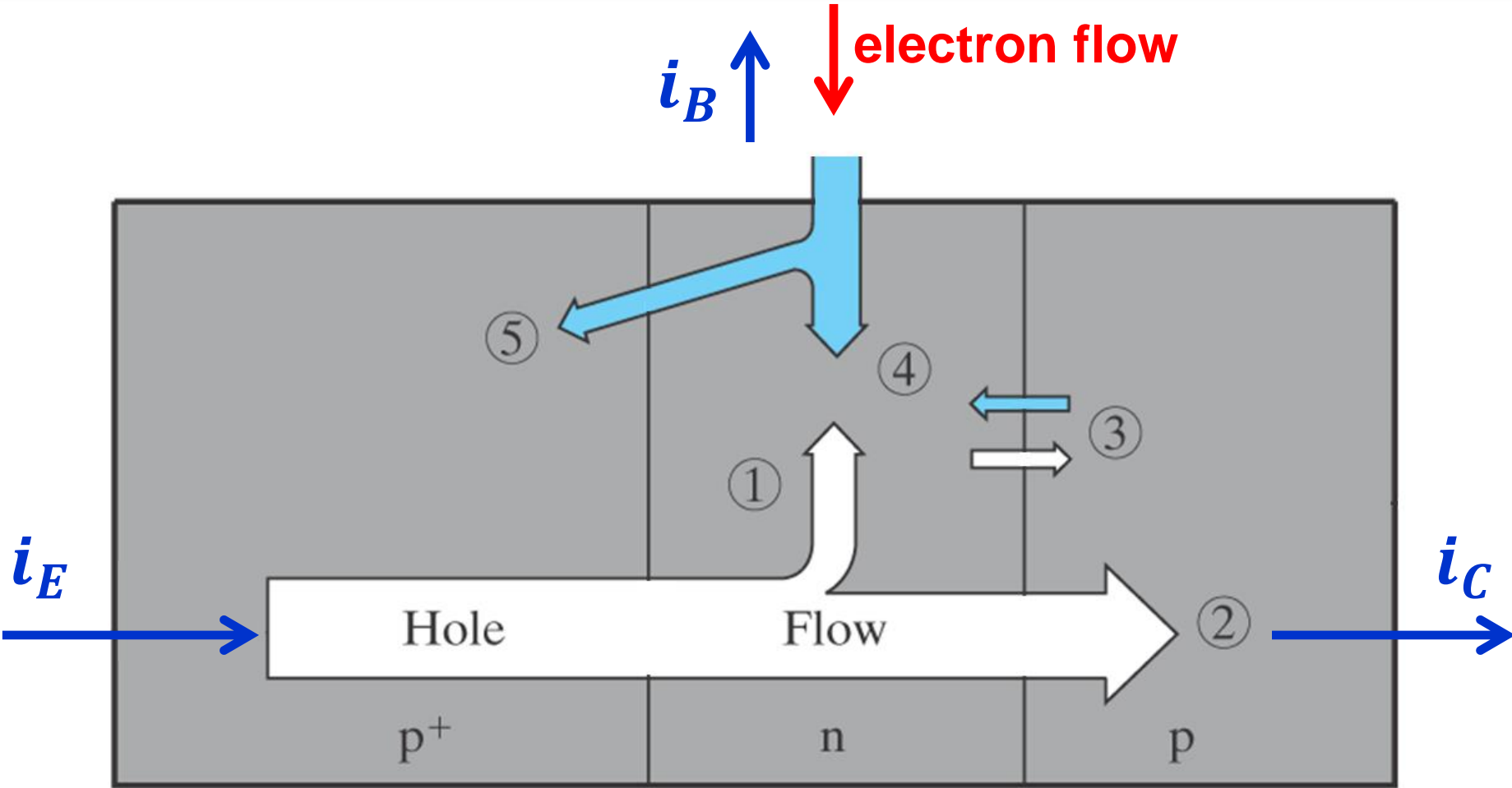
current generator

# BJT transistor I-V curves



The control input is the base current  $i_B$

# Carrier flow



$$\begin{array}{c}
 \xrightarrow{i_E} = \left\{ \begin{array}{l} \xrightarrow{i_{Ep}} \\ \xrightarrow{i_{En}} \end{array} \right. \quad \xrightarrow{i_C}
 \end{array}$$